

On Optimization of Manufacturing of Instrumentation Amplifier Input Bias Circuitry to Increase Density of Elements

E.L. Pankratov^{1,2}

¹Nizhny Novgorod State University, 23 Gagarin Avenue, Nizhny Novgorod, 603950, Russia

²Nizhny Novgorod State Technical University, 24 Minin Street, Nizhny Novgorod, 603950, Russia

ABSTRACT: In this paper, we introduce an approach to increase density of field-effect transistors framework instrumentation amplifier input bias circuitry. Framework the approach, we consider the manufacturing of inverter in heterostructure with specific configuration. Several required areas of the heterostructure should be doped by diffusion or ion implantation. Moreover, do pant and radiation defects should by annealed framework by optimized scheme. We also consider an approach to decrease value of mismatch-induced stress in the considered heterostructure. We introduce an analytical approach to analyze mass and heat transport in heterostructures during manufacturing of integrated circuits with account mismatch-induced stress.

KEYWORDS: instrumentation amplifier input bias circuitry; optimization of manufacturing; analytical approach for modelling.

<https://doi.org/10.29294/IJASE.7.4.2021.1912-1935>

© 2021 Mahendrapublications.com, All rights

INTRODUCTION

At present, several problems of the solid state electronics (increasing performance, reliability, density of elements of integrated circuits: diodes, field-effect and bipolar transistors) are intensively solving [1-6]. To increase the performance of these devices it is interesting to determine the materials with higher values of charge carrier mobility [7-10]. One way to decrease the dimensions of elements of integrated circuits is to manufacturing them in thin film heterostructures [3-5,11]. In this case, it is possible to use inhomogeneity of heterostructure and necessary optimization of doping of electronic materials [12] and development of epitaxial technology to improve these materials (including analysis of mismatch induced stress) [13-15]. An alternative approach to increase the dimensions of integrated circuits are using of laser and microwave types of annealing [16-18].

In this article, we introduce an approach to manufacture the field-effect transistors. This approach gives a possibility to decrease their dimensions with increasing their density framework, an instrumentation amplifier input bias circuitry. We also consider the possibility to decrease the mismatch-induced stress to decrease the quantity of defects, generated due to the stress. We also consider the heterostructure, which consist of a substrate and an epitaxial layer (see Fig. 1), a buffer layer between the substrate and the epitaxial layer. The epitaxial layer includes several sections, which were manufactured by using other materials. These sections have been doped by diffusion or ion implantation to manufacture the required types of conductivity (p

or n). These areas became sources, drains and gates (Fig.1). After doping it is required to annealing of dopant and/or radiation defects. The aim of this paper is to analysis of redistribution of dopant and radiation defects to determine conditions, which correspond to decreasing of elements of the considered filter and at the same time to increase their density. At the same time, we consider a possibility to decrease mismatch-induced stress.

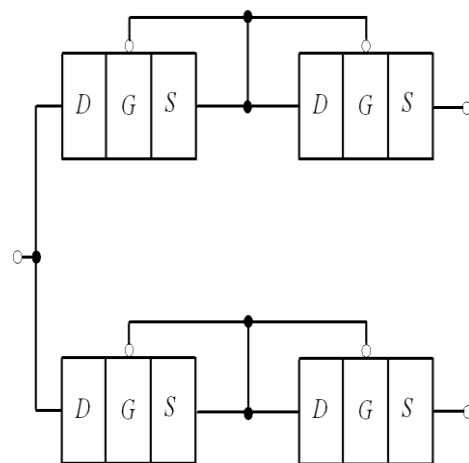


Fig. 1a. Structure of the considered amplifier [24]

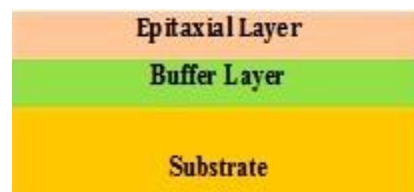


Fig. 1b. Heterostructure with a substrate, epitaxial

*Corresponding Author: elp2004@mail.ru

Received: 10.03.2021

Accepted: 25.04.2021

Published on: 31.05.2021

METHOD OF SOLUTION

To solve our aim we determine and analyzed spatio-temporal distribution of concentration of dopant in the considered heterostructure. We also determine the distribution by solving the second Fick's law in the following form [1,19-23]

$$\begin{aligned} \frac{\partial C(x, y, z, t)}{\partial t} = & \frac{\partial}{\partial x} \left[D \frac{\partial C(x, y, z, t)}{\partial x} \right] + \frac{\partial}{\partial y} \left[D \frac{\partial C(x, y, z, t)}{\partial y} \right] + \frac{\partial}{\partial z} \left[D \frac{\partial C(x, y, z, t)}{\partial z} \right] + \\ & + \Omega \frac{\partial}{\partial x} \left[\frac{D_s}{kT} \nabla_s \mu_1(x, y, z, t) \int_0^{L_z} C(x, y, W, t) dW \right] + \\ & + \Omega \frac{\partial}{\partial y} \left[\frac{D_s}{kT} \nabla_s \mu_1(x, y, z, t) \int_0^{L_z} C(x, y, W, t) dW \right] \quad (1) \end{aligned}$$

with boundary and initial conditions

$$\begin{aligned} \left. \frac{\partial C(x, y, z, t)}{\partial x} \right|_{x=0} = 0, \quad \left. \frac{\partial C(x, y, z, t)}{\partial x} \right|_{x=L_x} = 0, \quad \left. \frac{\partial C(x, y, z, t)}{\partial y} \right|_{y=0} = 0, \quad C(x, y, z, 0) = f_c(x, y, z), \\ \left. \frac{\partial C(x, y, z, t)}{\partial y} \right|_{y=L_y} = 0, \quad \left. \frac{\partial C(x, y, z, t)}{\partial z} \right|_{z=0} = 0, \quad \left. \frac{\partial C(x, y, z, t)}{\partial z} \right|_{z=L_z} = 0. \end{aligned}$$

Here $C(x, y, z, t)$ is the spatio-temporal distribution of concentration of dopant; Ω is the atomic volume of dopant; ∇_s is the symbol of surficial gradient; $\int_0^{L_z} C(x, y, z, t) dz$ is the surficial concentration of dopant on

interface between layers of heterostructure (in this situation we assume, that Z-axis is perpendicular to interface between layers of heterostructure); $\mu_1(x, y, z, t)$ is the chemical potential due to the presence of mismatch-induced stress; D and D_s are the coefficients of volumetric and surficial diffusions. The values of dopant diffusions coefficients depends on properties of materials of heterostructure, speed of heating and cooling of materials during annealing and spatio-temporal distribution of concentration of dopant. Dependences of dopant diffusions coefficients on parameters could be approximated by the following relations [21-23]

$$\begin{aligned} D_C = D_L(x, y, z, T) \left[1 + \xi \frac{C^\gamma(x, y, z, T)}{P^\gamma(x, y, z, T)} \right] \left[1 + \varsigma_1 \frac{V(x, y, z, t)}{V^*} + \varsigma_2 \frac{V^2(x, y, z, t)}{(V^*)^2} \right], \\ D_S = D_{SL}(x, y, z, T) \left[1 + \xi_S \frac{C^\gamma(x, y, z, T)}{P^\gamma(x, y, z, T)} \right] \left[1 + \varsigma_1 \frac{V(x, y, z, t)}{V^*} + \varsigma_2 \frac{V^2(x, y, z, t)}{(V^*)^2} \right]. \quad (2) \end{aligned}$$

Here $D_L(x, y, z, T)$ and $D_{LS}(x, y, z, T)$ are the spatial (due to accounting all layers of heterostructure) and temperature (due to Arrhenius law) dependences of dopant diffusion coefficients; T is the temperature of annealing; $P(x, y, z, T)$ is the limit of solubility of dopant; parameter γ depends on properties of materials and could be integer in the following interval $\gamma \in [1, 3]$ [21]; $V(x, y, z, t)$ is the spatio-temporal distribution of concentration of radiation vacancies; V^* is the equilibrium distribution of vacancies. The concentrational dependence of dopant diffusion coefficient has been described in details in [21]. The spatio-temporal distributions of concentration of point radiation defects have been determined by solving the following system of equations [19,22,23]

$$\begin{aligned}
\frac{\partial I(x, y, z, t)}{\partial t} &= \frac{\partial}{\partial x} \left[D_I(x, y, z, T) \frac{\partial I(x, y, z, t)}{\partial x} \right] + \frac{\partial}{\partial y} \left[D_I(x, y, z, T) \frac{\partial I(x, y, z, t)}{\partial y} \right] + \\
&+ \frac{\partial}{\partial z} \left[D_I(x, y, z, T) \frac{\partial I(x, y, z, t)}{\partial z} \right] - k_{I,I}(x, y, z, T) I^2(x, y, z, t) - k_{I,V}(x, y, z, T) \times \\
&\times I(x, y, z, t) V(x, y, z, t) + \Omega \frac{\partial}{\partial x} \left[\frac{D_{IS}}{kT} \nabla_s \mu(x, y, z, t) \int_0^{L_z} I(x, y, W, t) dW \right] + \\
&+ \Omega \frac{\partial}{\partial y} \left[\frac{D_{IS}}{kT} \nabla_s \mu(x, y, z, t) \int_0^{L_z} I(x, y, W, t) dW \right] \quad (3) \\
\frac{\partial V(x, y, z, t)}{\partial t} &= \frac{\partial}{\partial x} \left[D_V(x, y, z, T) \frac{\partial V(x, y, z, t)}{\partial x} \right] + \frac{\partial}{\partial y} \left[D_V(x, y, z, T) \frac{\partial V(x, y, z, t)}{\partial y} \right] + \\
&+ \frac{\partial}{\partial z} \left[D_V(x, y, z, T) \frac{\partial V(x, y, z, t)}{\partial z} \right] - k_{V,V}(x, y, z, T) V^2(x, y, z, t) - k_{I,V}(x, y, z, T) \times \\
&\times I(x, y, z, t) V(x, y, z, t) + \Omega \frac{\partial}{\partial x} \left[\frac{D_{VS}}{kT} \nabla_s \mu(x, y, z, t) \int_0^{L_z} V(x, y, W, t) dW \right] + \\
&+ \Omega \frac{\partial}{\partial y} \left[\frac{D_{VS}}{kT} \nabla_s \mu(x, y, z, t) \int_0^{L_z} V(x, y, W, t) dW \right]
\end{aligned}$$

with boundary and initial conditions

$$\begin{aligned}
\left. \frac{\partial I(x, y, z, t)}{\partial x} \right|_{x=0} &= 0, \left. \frac{\partial I(x, y, z, t)}{\partial x} \right|_{x=L_x} = 0, \left. \frac{\partial I(x, y, z, t)}{\partial y} \right|_{y=0} = 0, \\
\left. \frac{\partial I(x, y, z, t)}{\partial y} \right|_{y=L_y} &= 0, \left. \frac{\partial I(x, y, z, t)}{\partial z} \right|_{z=0} = 0, \left. \frac{\partial I(x, y, z, t)}{\partial z} \right|_{z=L_z} = 0, \\
\left. \frac{\partial V(x, y, z, t)}{\partial x} \right|_{x=0} &= 0, \left. \frac{\partial V(x, y, z, t)}{\partial x} \right|_{x=L_x} = 0, \left. \frac{\partial V(x, y, z, t)}{\partial y} \right|_{y=0} = 0, \quad (4) \\
\left. \frac{\partial V(x, y, z, t)}{\partial y} \right|_{y=L_y} &= 0, \left. \frac{\partial V(x, y, z, t)}{\partial z} \right|_{z=0} = 0, \left. \frac{\partial V(x, y, z, t)}{\partial z} \right|_{z=L_z} = 0
\end{aligned}$$

$$I(x, y, z, 0) = f_I(x, y, z), V(x, y, z, 0) = f_V(x, y, z).$$

Here $I(x, y, z, t)$ is the spatio-temporal distribution of concentration of radiation interstitials; I^* is the equilibrium distribution of interstitials; $D_I(x, y, z, T)$, $D_V(x, y, z, T)$, $D_{IS}(x, y, z, T)$, $D_{VS}(x, y, z, T)$ are the coefficients of volumetric and surficial diffusions of interstitials and vacancies, respectively; terms $V^2(x, y, z, t)$ and $I^2(x, y, z, t)$ correspond to generation of divacancies and diinterstitials, respectively [see, for example, [23] and

appropriate references in this book); $k_{I,V}(x,y,z,T)$, $k_{I,I}(x,y,z,T)$ and $k_{V,V}(x,y,z,T)$ are the parameters of recombination of point radiation defects and generation of their complexes.

Spatio-temporal distributions of divacancies $\Phi_V(x,y,z,t)$ and diinterstitials $\Phi_I(x,y,z,t)$ could be determined by solving the following system of equations [19,22,23]

$$\begin{aligned} \frac{\partial \Phi_I(x,y,z,t)}{\partial t} = & \frac{\partial}{\partial x} \left[D_{\Phi_I}(x,y,z,T) \frac{\partial \Phi_I(x,y,z,t)}{\partial x} \right] + \frac{\partial}{\partial y} \left[D_{\Phi_I}(x,y,z,T) \frac{\partial \Phi_I(x,y,z,t)}{\partial y} \right] + \\ & + \frac{\partial}{\partial z} \left[D_{\Phi_I}(x,y,z,T) \frac{\partial \Phi_I(x,y,z,t)}{\partial z} \right] + \Omega \frac{\partial}{\partial x} \left[\frac{D_{\Phi_I S}}{kT} \nabla_s \mu_1(x,y,z,t) \int_0^{L_z} \Phi_I(x,y,W,t) dW \right] + \\ & + \Omega \frac{\partial}{\partial y} \left[\frac{D_{\Phi_I S}}{kT} \nabla_s \mu_1(x,y,z,t) \int_0^{L_z} \Phi_I(x,y,W,t) dW \right] + k_{I,I}(x,y,z,T) I^2(x,y,z,t) + \\ & + k_I(x,y,z,T) I(x,y,z,t) \end{aligned} \quad (5)$$

$$\begin{aligned} \frac{\partial \Phi_V(x,y,z,t)}{\partial t} = & \frac{\partial}{\partial x} \left[D_{\Phi_V}(x,y,z,T) \frac{\partial \Phi_V(x,y,z,t)}{\partial x} \right] + \frac{\partial}{\partial y} \left[D_{\Phi_V}(x,y,z,T) \frac{\partial \Phi_V(x,y,z,t)}{\partial y} \right] + \\ & + \frac{\partial}{\partial z} \left[D_{\Phi_V}(x,y,z,T) \frac{\partial \Phi_V(x,y,z,t)}{\partial z} \right] + \Omega \frac{\partial}{\partial x} \left[\frac{D_{\Phi_V S}}{kT} \nabla_s \mu_1(x,y,z,t) \int_0^{L_z} \Phi_V(x,y,W,t) dW \right] + \\ & + \Omega \frac{\partial}{\partial y} \left[\frac{D_{\Phi_V S}}{kT} \nabla_s \mu_1(x,y,z,t) \int_0^{L_z} \Phi_V(x,y,W,t) dW \right] + k_{V,V}(x,y,z,T) V^2(x,y,z,t) + \\ & + k_V(x,y,z,T) V(x,y,z,t) \end{aligned}$$

with boundary and initial conditions

$$\begin{aligned} \left. \frac{\partial \Phi_I(x,y,z,t)}{\partial x} \right|_{x=0} = 0, \left. \frac{\partial \Phi_I(x,y,z,t)}{\partial x} \right|_{x=L_x} = 0, \left. \frac{\partial \Phi_I(x,y,z,t)}{\partial y} \right|_{y=0} = 0, \\ \left. \frac{\partial \Phi_I(x,y,z,t)}{\partial y} \right|_{y=L_y} = 0, \left. \frac{\partial \Phi_I(x,y,z,t)}{\partial z} \right|_{z=0} = 0, \left. \frac{\partial \Phi_I(x,y,z,t)}{\partial z} \right|_{z=L_z} = 0, \\ \left. \frac{\partial \Phi_V(x,y,z,t)}{\partial x} \right|_{x=0} = 0, \left. \frac{\partial \Phi_V(x,y,z,t)}{\partial x} \right|_{x=L_x} = 0, \left. \frac{\partial \Phi_V(x,y,z,t)}{\partial y} \right|_{y=0} = 0, \quad (6) \\ \left. \frac{\partial \Phi_V(x,y,z,t)}{\partial y} \right|_{y=L_y} = 0, \left. \frac{\partial \Phi_V(x,y,z,t)}{\partial z} \right|_{z=0} = 0, \left. \frac{\partial \Phi_V(x,y,z,t)}{\partial z} \right|_{z=L_z} = 0, \\ \Phi_I(x,y,z,0) = f_{\Phi I}(x,y,z), \Phi_V(x,y,z,0) = f_{\Phi V}(x,y,z). \end{aligned}$$

Here $D_{\phi l}(x,y,z,T)$, $D_{\phi v}(x,y,z,T)$, $D_{\phi s}(x,y,z,T)$ and $D_{\phi vs}(x,y,z,T)$ are the coefficients of volumetric and surficial diffusions of complexes of radiation defects; $k_l(x,y,z,T)$ and $k_v(x,y,z,T)$ are the parameters of decay of complexes of radiation defects.

Chemical potential μ_1 in Eq.(1) could be determine by the following relation [19]

$$\mu_1 = E(z) \Omega \sigma_{ij} [u_{ij}(x,y,z,t) + u_{ji}(x,y,z,t)] / 2, \quad (7)$$

where $E(z)$ is the Young modulus, σ_{ij} is the stress tensor; $u_{ij} = \frac{1}{2} \left(\frac{\partial u_i}{\partial x_j} + \frac{\partial u_j}{\partial x_i} \right)$ is the deformation tensor; u_i , u_j are the components $u_x(x,y,z,t)$, $u_y(x,y,z,t)$ and $u_z(x,y,z,t)$ of the displacement vector $\vec{u}(x,y,z,t)$; x_i , x_j are the coordinate x , y , z . The Eq. (3) could be transform to the following form

$$\mu(x,y,z,t) = \left[\frac{\partial u_i(x,y,z,t)}{\partial x_j} + \frac{\partial u_j(x,y,z,t)}{\partial x_i} \right] \left\{ \frac{1}{2} \left[\frac{\partial u_i(x,y,z,t)}{\partial x_j} + \frac{\partial u_j(x,y,z,t)}{\partial x_i} \right] - \varepsilon_0 \delta_{ij} + \frac{\sigma(z) \delta_{ij}}{1-2\sigma(z)} \left[\frac{\partial u_k(x,y,z,t)}{\partial x_k} - 3\varepsilon_0 \right] - K(z) \beta(z) [T(x,y,z,t) - T_0] \delta_{ij} \right\} \frac{\Omega}{2} E(z),$$

where σ is Poisson coefficient; $\varepsilon_0 = (a_s - a_{EL}) / a_{EL}$ is the mismatch parameter; a_s , a_{EL} are lattice distances of the substrate and the epitaxial layer; K is the modulus of uniform compression; β is the coefficient of thermal expansion; T_r is the equilibrium temperature, which coincide (for our case) with room temperature. Components of displacement vector could be obtained by solution of the following equations [25]

$$\begin{cases} \rho(z) \frac{\partial^2 u_x(x,y,z,t)}{\partial t^2} = \frac{\partial \sigma_{xx}(x,y,z,t)}{\partial x} + \frac{\partial \sigma_{xy}(x,y,z,t)}{\partial y} + \frac{\partial \sigma_{xz}(x,y,z,t)}{\partial z} \\ \rho(z) \frac{\partial^2 u_y(x,y,z,t)}{\partial t^2} = \frac{\partial \sigma_{yx}(x,y,z,t)}{\partial x} + \frac{\partial \sigma_{yy}(x,y,z,t)}{\partial y} + \frac{\partial \sigma_{yz}(x,y,z,t)}{\partial z} \\ \rho(z) \frac{\partial^2 u_z(x,y,z,t)}{\partial t^2} = \frac{\partial \sigma_{zx}(x,y,z,t)}{\partial x} + \frac{\partial \sigma_{zy}(x,y,z,t)}{\partial y} + \frac{\partial \sigma_{zz}(x,y,z,t)}{\partial z} \end{cases}$$

where

$$\sigma_{ij} = \frac{E(z)}{2[1+\sigma(z)]} \left[\frac{\partial u_i(x,y,z,t)}{\partial x_j} + \frac{\partial u_j(x,y,z,t)}{\partial x_i} - \frac{\delta_{ij}}{3} \frac{\partial u_k(x,y,z,t)}{\partial x_k} \right] + K(z) \delta_{ij} \times \frac{\partial u_k(x,y,z,t)}{\partial x_k} - \beta(z) K(z) [T(x,y,z,t) - T_r], \rho(z) \text{ is the density of materials of}$$

heterostructure, δ_{ij} is the Kronecker symbol. With account the relation for σ_{ij} last system of equation could be written as

$$\begin{aligned} \rho(z) \frac{\partial^2 u_x(x,y,z,t)}{\partial t^2} &= \left\{ K(z) + \frac{5E(z)}{6[1+\sigma(z)]} \right\} \frac{\partial^2 u_x(x,y,z,t)}{\partial x^2} + \left\{ K(z) - \frac{E(z)}{3[1+\sigma(z)]} \right\} \times \\ &\times \frac{\partial^2 u_y(x,y,z,t)}{\partial x \partial y} + \frac{E(z)}{2[1+\sigma(z)]} \left[\frac{\partial^2 u_y(x,y,z,t)}{\partial y^2} + \frac{\partial^2 u_z(x,y,z,t)}{\partial z^2} \right] + \left[K(z) + \frac{E(z)}{3[1+\sigma(z)]} \right] \times \end{aligned}$$

$$\begin{aligned}
& \times \frac{\partial^2 u_z(x, y, z, t)}{\partial x \partial z} - K(z) \beta(z) \frac{\partial T(x, y, z, t)}{\partial x} \\
\rho(z) \frac{\partial^2 u_y(x, y, z, t)}{\partial t^2} &= \frac{E(z)}{2[1+\sigma(z)]} \left[\frac{\partial^2 u_y(x, y, z, t)}{\partial x^2} + \frac{\partial^2 u_x(x, y, z, t)}{\partial x \partial y} \right] - \frac{\partial T(x, y, z, t)}{\partial y} \times \\
& \times K(z) \beta(z) + \frac{\partial}{\partial z} \left\{ \frac{E(z)}{2[1+\sigma(z)]} \left[\frac{\partial u_y(x, y, z, t)}{\partial z} + \frac{\partial u_z(x, y, z, t)}{\partial y} \right] \right\} + \frac{\partial^2 u_y(x, y, z, t)}{\partial y^2} \times \\
& \times \left\{ \frac{5E(z)}{12[1+\sigma(z)]} + K(z) \right\} + \left\{ K(z) - \frac{E(z)}{6[1+\sigma(z)]} \right\} \frac{\partial^2 u_y(x, y, z, t)}{\partial y \partial z} + K(z) \frac{\partial^2 u_y(x, y, z, t)}{\partial x \partial y} \\
\rho(z) \frac{\partial^2 u_z(x, y, z, t)}{\partial t^2} &= \frac{E(z)}{2[1+\sigma(z)]} \left[\frac{\partial^2 u_z(x, y, z, t)}{\partial x^2} + \frac{\partial^2 u_z(x, y, z, t)}{\partial y^2} + \frac{\partial^2 u_x(x, y, z, t)}{\partial x \partial z} + \right. \\
& + \frac{\partial^2 u_y(x, y, z, t)}{\partial y \partial z} \left. \right] + \frac{\partial}{\partial z} \left\{ K(z) \left[\frac{\partial u_x(x, y, z, t)}{\partial x} + \frac{\partial u_y(x, y, z, t)}{\partial y} + \frac{\partial u_z(x, y, z, t)}{\partial z} \right] \right\} + \\
& + \frac{1}{6} \frac{\partial}{\partial z} \left\{ \frac{E(z)}{1+\sigma(z)} \left[6 \frac{\partial u_z(x, y, z, t)}{\partial z} - \frac{\partial u_x(x, y, z, t)}{\partial x} - \frac{\partial u_y(x, y, z, t)}{\partial y} - \frac{\partial u_z(x, y, z, t)}{\partial z} \right] \right\} - \\
& - K(z) \beta(z) \frac{\partial T(x, y, z, t)}{\partial z}.
\end{aligned}
\tag{8}$$

Conditions for the system of Eq. (8) could be written in the form

$$\begin{aligned}
\frac{\partial \bar{u}(0, y, z, t)}{\partial x} &= 0; \quad \frac{\partial \bar{u}(L_x, y, z, t)}{\partial x} = 0; \quad \frac{\partial \bar{u}(x, 0, z, t)}{\partial y} = 0; \quad \frac{\partial \bar{u}(x, L_y, z, t)}{\partial y} = 0; \\
\frac{\partial \bar{u}(x, y, 0, t)}{\partial z} &= 0; \quad \frac{\partial \bar{u}(x, y, L_z, t)}{\partial z} = 0; \quad \bar{u}(x, y, z, 0) = \bar{u}_0; \quad \bar{u}(x, y, z, \infty) = \bar{u}_0.
\end{aligned}$$

We determine spatio-temporal distributions of concentrations of dopant and radiation defects by solving the Eqs.(1), (3) and (5) framework standard method of averaging of function corrections [26]. Previously we transform the Eqs.(1), (3) and (5) to the following form with account initial distributions of the considered concentrations

$$\begin{aligned}
\frac{\partial C(x, y, z, t)}{\partial t} &= \frac{\partial}{\partial x} \left[D \frac{\partial C(x, y, z, t)}{\partial x} \right] + \frac{\partial}{\partial y} \left[D \frac{\partial C(x, y, z, t)}{\partial y} \right] + \frac{\partial}{\partial z} \left[D \frac{\partial C(x, y, z, t)}{\partial z} \right] + \\
& + f_c(x, y, z) \delta(t) + \Omega \frac{\partial}{\partial x} \left[\frac{D_s}{kT} \nabla_s \mu(x, y, z, t) \int_0^{L_z} C(x, y, W, t) dW \right] +
\end{aligned}
\tag{1a}$$

$$\begin{aligned}
& + \Omega \frac{\partial}{\partial y} \left[\frac{D_s}{kT} \nabla_s \mu(x, y, z, t) \int_0^{L_z} C(x, y, W, t) dW \right] \\
\frac{\partial I(x, y, z, t)}{\partial t} = & \frac{\partial}{\partial x} \left[D_I(x, y, z, T) \frac{\partial I(x, y, z, t)}{\partial x} \right] + \frac{\partial}{\partial y} \left[D_I(x, y, z, T) \frac{\partial I(x, y, z, t)}{\partial y} \right] + \\
& + \frac{\partial}{\partial z} \left[D_I(x, y, z, T) \frac{\partial I(x, y, z, t)}{\partial z} \right] + \Omega \frac{\partial}{\partial x} \left[\frac{D_{IS}}{kT} \nabla_s \mu_1(x, y, z, t) \int_0^{L_z} I(x, y, W, t) dW \right] + \\
& + \Omega \frac{\partial}{\partial y} \left[\frac{D_{IS}}{kT} \nabla_s \mu_1(x, y, z, t) \int_0^{L_z} I(x, y, W, t) dW \right] - k_{I,I}(x, y, z, T) I^2(x, y, z, t) - \\
& - k_{I,V}(x, y, z, T) I(x, y, z, t) V(x, y, z, t) + f_I(x, y, z) \delta(t) \quad (3a)
\end{aligned}$$

$$\begin{aligned}
\frac{\partial V(x, y, z, t)}{\partial t} = & \frac{\partial}{\partial x} \left[D_V(x, y, z, T) \frac{\partial V(x, y, z, t)}{\partial x} \right] + \frac{\partial}{\partial y} \left[D_V(x, y, z, T) \frac{\partial V(x, y, z, t)}{\partial y} \right] + \\
& + \frac{\partial}{\partial z} \left[D_V(x, y, z, T) \frac{\partial V(x, y, z, t)}{\partial z} \right] + \Omega \frac{\partial}{\partial x} \left[\frac{D_{VS}}{kT} \nabla_s \mu_1(x, y, z, t) \int_0^{L_z} V(x, y, W, t) dW \right] + \\
& + \Omega \frac{\partial}{\partial y} \left[\frac{D_{VS}}{kT} \nabla_s \mu_1(x, y, z, t) \int_0^{L_z} V(x, y, W, t) dW \right] - k_{V,V}(x, y, z, T) V^2(x, y, z, t) - \\
& - k_{I,V}(x, y, z, T) I(x, y, z, t) V(x, y, z, t) + f_V(x, y, z) \delta(t) \\
\frac{\partial \Phi_I(x, y, z, t)}{\partial t} = & \frac{\partial}{\partial x} \left[D_{\Phi_I}(x, y, z, T) \frac{\partial \Phi_I(x, y, z, t)}{\partial x} \right] + \frac{\partial}{\partial y} \left[D_{\Phi_I}(x, y, z, T) \frac{\partial \Phi_I(x, y, z, t)}{\partial y} \right] + \\
& + \frac{\partial}{\partial z} \left[D_{\Phi_I}(x, y, z, T) \frac{\partial \Phi_I(x, y, z, t)}{\partial z} \right] + \Omega \frac{\partial}{\partial x} \left[\frac{D_{\Phi_{IS}}}{kT} \nabla_s \mu_1(x, y, z, t) \int_0^{L_z} \Phi_I(x, y, W, t) dW \right] + \\
& + \Omega \frac{\partial}{\partial y} \left[\frac{D_{\Phi_{IS}}}{kT} \nabla_s \mu_1(x, y, z, t) \int_0^{L_z} \Phi_I(x, y, W, t) dW \right] + k_I(x, y, z, T) I(x, y, z, t) + \\
& + k_{I,I}(x, y, z, T) I^2(x, y, z, t) + f_{\Phi_I}(x, y, z) \delta(t) \quad (5a)
\end{aligned}$$

$$\frac{\partial \Phi_V(x, y, z, t)}{\partial t} = \frac{\partial}{\partial x} \left[D_{\Phi_V}(x, y, z, T) \frac{\partial \Phi_V(x, y, z, t)}{\partial x} \right] + \frac{\partial}{\partial y} \left[D_{\Phi_V}(x, y, z, T) \frac{\partial \Phi_V(x, y, z, t)}{\partial y} \right] +$$

$$\begin{aligned}
& + \frac{\partial}{\partial z} \left[D_{\Phi_V}(x, y, z, T) \frac{\partial \Phi_V(x, y, z, t)}{\partial z} \right] + \Omega \frac{\partial}{\partial x} \left[\frac{D_{\Phi_V S}}{kT} \nabla_s \mu_1(x, y, z, t) \int_0^{L_z} \Phi_V(x, y, W, t) dW \right] + \\
& + \Omega \frac{\partial}{\partial y} \left[\frac{D_{\Phi_V S}}{kT} \nabla_s \mu_1(x, y, z, t) \int_0^{L_z} \Phi_V(x, y, W, t) dW \right] + k_V(x, y, z, T) V(x, y, z, t) + \\
& + k_{V,V}(x, y, z, T) V^2(x, y, z, t) + f_{\Phi_V}(x, y, z) \delta(t).
\end{aligned}$$

Further we replace concentrations of dopant and radiation defects in right sides of Eqs. (1a), (3a) and (5a), are not yet known average values $\alpha_{1\rho}$. In this situation we obtain equations for the first-order approximations of the required concentrations in the following form

$$\begin{aligned}
\frac{\partial C_1(x, y, z, t)}{\partial t} = & \alpha_{1C} \Omega \frac{\partial}{\partial x} \left[z \frac{D_S}{kT} \nabla_s \mu_1(x, y, z, t) \right] + \alpha_{1C} \Omega \frac{\partial}{\partial y} \left[z \frac{D_S}{kT} \nabla_s \mu_1(x, y, z, t) \right] + \\
& + f_C(x, y, z) \delta(t) \quad (1b)
\end{aligned}$$

$$\begin{aligned}
\frac{\partial I_1(x, y, z, t)}{\partial t} = & \alpha_{1I} z \Omega \frac{\partial}{\partial x} \left[\frac{D_{IS}}{kT} \nabla_s \mu(x, y, z, t) \right] + \alpha_{1I} \Omega \frac{\partial}{\partial y} \left[z \frac{D_{IS}}{kT} \nabla_s \mu(x, y, z, t) \right] + \\
& + f_I(x, y, z) \delta(t) - \alpha_{1I}^2 k_{I,I}(x, y, z, T) - \alpha_{1I} \alpha_{1V} k_{I,V}(x, y, z, T) \quad (3b)
\end{aligned}$$

$$\begin{aligned}
\frac{\partial V_1(x, y, z, t)}{\partial t} = & \alpha_{1V} z \Omega \frac{\partial}{\partial x} \left[\frac{D_{VS}}{kT} \nabla_s \mu_1(x, y, z, t) \right] + \alpha_{1V} \Omega \frac{\partial}{\partial y} \left[z \frac{D_{VS}}{kT} \nabla_s \mu_1(x, y, z, t) \right] + \\
& + f_V(x, y, z) \delta(t) - \alpha_{1V}^2 k_{V,V}(x, y, z, T) - \alpha_{1I} \alpha_{1V} k_{I,V}(x, y, z, T) \\
\frac{\partial \Phi_{1I}(x, y, z, t)}{\partial t} = & \alpha_{1\Phi_I} z \Omega \frac{\partial}{\partial x} \left[\frac{D_{\Phi_I S}}{kT} \nabla_s \mu_1(x, y, z, t) \right] + \alpha_{1\Phi_I} z \Omega \frac{\partial}{\partial y} \left[\frac{D_{\Phi_I S}}{kT} \nabla_s \mu_1(x, y, z, t) \right] + \\
& + f_{\Phi_I}(x, y, z) \delta(t) + k_I(x, y, z, T) I(x, y, z, t) + k_{I,I}(x, y, z, T) I^2(x, y, z, t) \quad (5b)
\end{aligned}$$

$$\begin{aligned}
\frac{\partial \Phi_{1V}(x, y, z, t)}{\partial t} = & \alpha_{1\Phi_V} z \Omega \frac{\partial}{\partial x} \left[\frac{D_{\Phi_V S}}{kT} \nabla_s \mu_1(x, y, z, t) \right] + \alpha_{1\Phi_V} z \Omega \frac{\partial}{\partial y} \left[\frac{D_{\Phi_V S}}{kT} \nabla_s \mu_1(x, y, z, t) \right] + \\
& + f_{\Phi_V}(x, y, z) \delta(t) + k_V(x, y, z, T) V(x, y, z, t) + k_{V,V}(x, y, z, T) V^2(x, y, z, t).
\end{aligned}$$

Integration of the left and right sides of the Eqs. (1b), (3b) and (5b) on time gives us possibility to obtain relations for above approximation in the final form

$$C_1(x, y, z, t) = \alpha_{1C} \Omega \frac{\partial}{\partial x} \int_0^t D_{SL}(x, y, z, T) \frac{z}{kT} \left[1 + \varsigma_1 \frac{V(x, y, z, \tau)}{V^*} + \varsigma_2 \frac{V^2(x, y, z, \tau)}{(V^*)^2} \right] \times$$

$$\times \nabla_s \mu_1(x, y, z, \tau) \left[1 + \frac{\xi_s \alpha_{1C}^\gamma}{P^\gamma(x, y, z, T)} \right] d\tau \Big\} + \alpha_{1C} \frac{\partial}{\partial y} \int_0^t D_{sL}(x, y, z, T) \left[1 + \frac{\xi_s \alpha_{1C}^\gamma}{P^\gamma(x, y, z, T)} \right] +$$

$$\times \Omega \nabla_s \mu_1(x, y, z, \tau) \frac{z}{kT} \left[1 + \varsigma_1 \frac{V(x, y, z, \tau)}{V^*} + \varsigma_2 \frac{V^2(x, y, z, \tau)}{(V^*)^2} \right] d\tau + f_c(x, y, z) \quad (1c)$$

$$I_1(x, y, z, t) = \alpha_{1I} z \Omega \frac{\partial}{\partial x} \int_0^t \frac{D_{IS}}{kT} \nabla_s \mu_1(x, y, z, \tau) d\tau + \alpha_{1I} z \Omega \frac{\partial}{\partial y} \int_0^t \frac{D_{IS}}{kT} \nabla_s \mu_1(x, y, z, \tau) d\tau +$$

$$+ f_I(x, y, z) - \alpha_{1I}^2 \int_0^t k_{I,I}(x, y, z, T) d\tau - \alpha_{1I} \alpha_{1V} \int_0^t k_{I,V}(x, y, z, T) d\tau \quad (3c)$$

$$V_1(x, y, z, t) = \alpha_{1V} z \Omega \frac{\partial}{\partial x} \int_0^t \frac{D_{IS}}{kT} \nabla_s \mu_1(x, y, z, \tau) d\tau + \alpha_{1V} z \Omega \frac{\partial}{\partial y} \int_0^t \frac{D_{IS}}{kT} \nabla_s \mu_1(x, y, z, \tau) d\tau +$$

$$+ f_V(x, y, z) - \alpha_{1V}^2 \int_0^t k_{V,V}(x, y, z, T) d\tau - \alpha_{1I} \alpha_{1V} \int_0^t k_{I,V}(x, y, z, T) d\tau$$

$$\Phi_{1I}(x, y, z, t) = \alpha_{1\Phi_I} z \Omega \frac{\partial}{\partial x} \int_0^t \frac{D_{\Phi IS}}{kT} \nabla_s \mu_1(x, y, z, \tau) d\tau + \Omega \frac{\partial}{\partial x} \int_0^t \frac{D_{\Phi IS}}{kT} \nabla_s \mu_1(x, y, z, \tau) d\tau \times$$

$$\times \alpha_{1\Phi_I} z + f_{\Phi_I}(x, y, z) + \int_0^t k_I(x, y, z, T) I(x, y, z, \tau) d\tau + \int_0^t k_{I,I}(x, y, z, T) I^2(x, y, z, \tau) d\tau$$

$$(5c)$$

$$\Phi_{1V}(x, y, z, t) = \alpha_{1\Phi_V} z \Omega \frac{\partial}{\partial x} \int_0^t \frac{D_{\Phi VS}}{kT} \nabla_s \mu_1(x, y, z, \tau) d\tau + \Omega \frac{\partial}{\partial x} \int_0^t \frac{D_{\Phi VS}}{kT} \nabla_s \mu_1(x, y, z, \tau) d\tau \times$$

$$\times \alpha_{1\Phi_V} z + f_{\Phi_V}(x, y, z) + \int_0^t k_V(x, y, z, T) V(x, y, z, \tau) d\tau + \int_0^t k_{V,V}(x, y, z, T) V^2(x, y, z, \tau) d\tau$$

We determine average values of the first-order approximations of concentrations of dopant and radiation defects by the following standard relation [26]

$$\alpha_{1\rho} = \frac{1}{\Theta L_x L_y L_z} \int_0^{\Theta} \int_0^{L_x} \int_0^{L_y} \int_0^{L_z} \rho_1(x, y, z, t) dz dy dx dt. \quad (9)$$

Substitution of the relations (1c), (3c) and (5c) into relation (9) gives us possibility to obtain required average values in the following form

$$\alpha_{1C} = \frac{1}{L_x L_y L_z} \int_0^{L_x} \int_0^{L_y} \int_0^{L_z} f_C(x, y, z) dz dy dx,$$

$$\alpha_{II} = \sqrt{\frac{(a_3 + A)^2}{4a_4^2} - 4 \left(B + \frac{\Theta a_3 B + \Theta^2 L_x L_y L_z a_1}{a_4} \right) - \frac{a_3 + A}{4a_4}}, \alpha_{IV} = \frac{1}{S_{IV00}} \left[\frac{\Theta}{\alpha_{II}} \int_0^{L_x} \int_0^{L_y} \int_0^{L_z} f_I(x, y, z) dz dy dx - \alpha_{II} S_{II00} - \Theta L_x L_y L_z \right],$$

where $S_{\rho\rho ij} = \int_0^\Theta (\Theta - t) \int_0^{L_x} \int_0^{L_y} \int_0^{L_z} k_{\rho,\rho}(x, y, z, T) I_1^i(x, y, z, t) V_1^j(x, y, z, t) dz dy dx dt,$

$$a_4 = S_{II00} \times$$

$$\times (S_{IV00}^2 - S_{II00} S_{VV00}),$$

$$a_3 = S_{IV00} S_{II00} + S_{IV00}^2 - S_{II00} S_{VV00},$$

$$a_2 = \int_0^{L_x} \int_0^{L_y} \int_0^{L_z} f_V(x, y, z) dz dy dx \times$$

$$\times S_{IV00} S_{IV00}^2 + S_{IV00} \Theta L_x^2 L_y^2 L_z^2 + 2 S_{VV00} S_{II00} \int_0^{L_x} \int_0^{L_y} \int_0^{L_z} f_I(x, y, z) dz dy dx - \Theta L_x^2 L_y^2 L_z^2 S_{VV00} -$$

$$- S_{IV00}^2 \int_0^{L_x} \int_0^{L_y} \int_0^{L_z} f_I(x, y, z) dz dy dx, a_1 = S_{IV00} \int_0^{L_x} \int_0^{L_y} \int_0^{L_z} f_I(x, y, z) dz dy dx, a_0 = S_{VV00} \times$$

$$\times \left[\int_0^{L_x} \int_0^{L_y} \int_0^{L_z} f_I(x, y, z) dz dy dx \right]^2,$$

$$A = \sqrt{8y + \Theta^2 \frac{a_3^2}{a_4^2} - 4\Theta \frac{a_2}{a_4}},$$

$$B = \frac{\Theta a_2}{6a_4} + \sqrt[3]{\sqrt{q^2 + p^3} - q} -$$

$$- \sqrt[3]{\sqrt{q^2 + p^3} + q}, q = \frac{\Theta^3 a_2}{24 a_4^2} \left(4a_0 - \Theta L_x L_y L_z \frac{a_1 a_3}{a_4} \right) - \Theta^2 \frac{a_0}{8 a_4^2} \left(4\Theta a_2 - \Theta^2 \frac{a_3^2}{a_4} \right) -$$

$$- \frac{\Theta^3 a_2^3}{54 a_4^3} - L_x^2 L_y^2 L_z^2 \frac{\Theta^4 a_1^2}{8 a_4^2}, p = \Theta^2 \frac{4a_0 a_4 - \Theta L_x L_y L_z a_1 a_3}{12 a_4^2} - \frac{\Theta a_2}{18 a_4},$$

$$\alpha_{1\Phi_I} = \frac{R_{I1}}{\Theta L_x L_y L_z} + \frac{S_{II20}}{\Theta L_x L_y L_z} + \frac{1}{L_x L_y L_z} \int_0^{L_x} \int_0^{L_y} \int_0^{L_z} f_{\Phi_I}(x, y, z) dz dy dx$$

$$\alpha_{1\Phi_V} = \frac{R_{V1}}{\Theta L_x L_y L_z} + \frac{S_{VV20}}{\Theta L_x L_y L_z} + \frac{1}{L_x L_y L_z} \int_0^{L_x} \int_0^{L_y} \int_0^{L_z} f_{\Phi_V}(x, y, z) dz dy dx,$$

where $R_{\rho i} = \int_0^\Theta (\Theta - t) \int_0^{L_x} \int_0^{L_y} \int_0^{L_z} k_I(x, y, z, T) I_1^i(x, y, z, t) dz dy dx dt.$

We determine approximations of the second and higher orders of concentrations of dopant and radiation defects framework standard iterative procedure of method of averaging of function corrections [26]. Framework this procedure to determine approximations of the n -th order of concentrations of dopant and radiation defects we replace the required concentrations in the Eqs. (1c), (3c), (5c) on the following sum $\alpha_{np} + \rho_{n-1}(x, y, z, t)$. The replacement leads to the following transformation of the appropriate equations

$$\begin{aligned} \frac{\partial C_2(x, y, z, t)}{\partial t} &= \frac{\partial}{\partial x} \left(\left\{ 1 + \xi \frac{[\alpha_{2c} + C_1(x, y, z, t)]^\gamma}{P^\gamma(x, y, z, T)} \right\} \left[1 + \varsigma_1 \frac{V(x, y, z, t)}{V^*} + \varsigma_2 \frac{V^2(x, y, z, t)}{(V^*)^2} \right] \times \right. \\ &\times D_L(x, y, z, T) \frac{\partial C_1(x, y, z, t)}{\partial x} \Bigg) + \frac{\partial}{\partial y} \left(\left[1 + \varsigma_1 \frac{V(x, y, z, t)}{V^*} + \varsigma_2 \frac{V^2(x, y, z, t)}{(V^*)^2} \right] \frac{\partial C_1(x, y, z, t)}{\partial y} \times \right. \\ &\times D_L(x, y, z, T) \left\{ 1 + \xi \frac{[\alpha_{2c} + C_1(x, y, z, t)]^\gamma}{P^\gamma(x, y, z, T)} \right\} \Bigg) + \frac{\partial}{\partial z} \left(\left[1 + \varsigma_1 \frac{V(x, y, z, t)}{V^*} + \varsigma_2 \frac{V^2(x, y, z, t)}{(V^*)^2} \right] \times \right. \\ &\times D_L(x, y, z, T) \frac{\partial C_1(x, y, z, t)}{\partial z} \left\{ 1 + \xi \frac{[\alpha_{2c} + C_1(x, y, z, t)]^\gamma}{P^\gamma(x, y, z, T)} \right\} \Bigg) + f_c(x, y, z) \delta(t) + \\ &+ \Omega \frac{\partial}{\partial x} \left\{ \frac{D_s}{kT} \nabla_s \mu_1(x, y, z, t) \int_0^{L_z} [\alpha_{2c} + C(x, y, W, t)] dW \right\} + \\ &\quad + \Omega \frac{\partial}{\partial y} \left\{ \frac{D_s}{kT} \nabla_s \mu_1(x, y, z, t) \int_0^{L_z} [\alpha_{2c} + C(x, y, W, t)] dW \right\} \quad (1d) \\ \frac{\partial I_2(x, y, z, t)}{\partial t} &= \frac{\partial}{\partial x} \left[D_I(x, y, z, T) \frac{\partial I_1(x, y, z, t)}{\partial x} \right] + \frac{\partial}{\partial y} \left[D_I(x, y, z, T) \frac{\partial I_1(x, y, z, t)}{\partial y} \right] + \\ &+ \frac{\partial}{\partial z} \left[D_I(x, y, z, T) \frac{\partial I_1(x, y, z, t)}{\partial z} \right] - k_{I,I}(x, y, z, T) [\alpha_{1I} + I_1(x, y, z, t)]^2 - k_{I,V}(x, y, z, T) \times \\ &\times [\alpha_{1I} + I_1(x, y, z, t)] [\alpha_{1V} + V_1(x, y, z, t)] + \Omega \frac{\partial}{\partial x} \left\{ \nabla_s \mu(x, y, z, t) \int_0^{L_z} [\alpha_{2I} + I_1(x, y, W, t)] dW \times \right. \\ &\quad \times \frac{D_{IS}}{kT} \Bigg\} + \Omega \frac{\partial}{\partial y} \left\{ \frac{D_{IS}}{kT} \nabla_s \mu(x, y, z, t) \int_0^{L_z} [\alpha_{2I} + I_1(x, y, W, t)] dW \right\} \quad (3d) \\ \frac{\partial V_2(x, y, z, t)}{\partial t} &= \frac{\partial}{\partial x} \left[D_V(x, y, z, T) \frac{\partial V_1(x, y, z, t)}{\partial x} \right] + \frac{\partial}{\partial y} \left[D_V(x, y, z, T) \frac{\partial V_1(x, y, z, t)}{\partial y} \right] + \end{aligned}$$

$$\begin{aligned}
& + \frac{\partial}{\partial z} \left[D_V(x, y, z, T) \frac{\partial V_1(x, y, z, t)}{\partial z} \right] - k_{V,V}(x, y, z, T) [\alpha_{1V} + V_1(x, y, z, t)]^2 - k_{I,V}(x, y, z, T) \times \\
& \times [\alpha_{1I} + I_1(x, y, z, t)] [\alpha_{1V} + V_1(x, y, z, t)] + \Omega \frac{\partial}{\partial x} \left\{ \nabla_s \mu(x, y, z, t) \int_0^{L_z} [\alpha_{2V} + V_1(x, y, W, t)] dW \times \right. \\
& \quad \times \frac{D_{VS}}{kT} \left. \right\} + \Omega \frac{\partial}{\partial y} \left\{ \frac{D_{VS}}{kT} \nabla_s \mu(x, y, z, t) \int_0^{L_z} [\alpha_{2V} + V_1(x, y, W, t)] dW \right\} \\
& \frac{\partial \Phi_{2I}(x, y, z, t)}{\partial t} = \frac{\partial}{\partial x} \left[D_{\Phi_I}(x, y, z, T) \frac{\partial \Phi_{1I}(x, y, z, t)}{\partial x} \right] + \frac{\partial}{\partial y} \left[D_{\Phi_I}(x, y, z, T) \frac{\partial \Phi_{1I}(x, y, z, t)}{\partial y} \right] + \\
& + \Omega \frac{\partial}{\partial x} \left\{ \frac{D_{\Phi_{IS}}}{kT} \nabla_s \mu(x, y, z, t) \int_0^{L_z} [\alpha_{2\Phi_I} + \Phi_{1I}(x, y, W, t)] dW \right\} + k_{I,I}(x, y, z, T) I^2(x, y, z, t) + \\
& + \Omega \frac{\partial}{\partial y} \left\{ \frac{D_{\Phi_{IS}}}{kT} \nabla_s \mu(x, y, z, t) \int_0^{L_z} [\alpha_{2\Phi_I} + \Phi_{1I}(x, y, W, t)] dW \right\} + k_I(x, y, z, T) I(x, y, z, t) + \\
& \quad + \frac{\partial}{\partial z} \left[D_{\Phi_I}(x, y, z, T) \frac{\partial \Phi_{1I}(x, y, z, t)}{\partial z} \right] + f_{\Phi_I}(x, y, z) \delta(t) \tag{5d} \\
& \frac{\partial \Phi_{2V}(x, y, z, t)}{\partial t} = \frac{\partial}{\partial x} \left[D_{\Phi_V}(x, y, z, T) \frac{\partial \Phi_{1V}(x, y, z, t)}{\partial x} \right] + \frac{\partial}{\partial y} \left[D_{\Phi_V}(x, y, z, T) \frac{\partial \Phi_{1V}(x, y, z, t)}{\partial y} \right] + \\
& + \Omega \frac{\partial}{\partial x} \left\{ \frac{D_{\Phi_{VS}}}{kT} \nabla_s \mu(x, y, z, t) \int_0^{L_z} [\alpha_{2\Phi_V} + \Phi_{1V}(x, y, W, t)] dW \right\} + k_{V,V}(x, y, z, T) V^2(x, y, z, t) + \\
& + \Omega \frac{\partial}{\partial y} \left\{ \frac{D_{\Phi_{VS}}}{kT} \nabla_s \mu(x, y, z, t) \int_0^{L_z} [\alpha_{2\Phi_V} + \Phi_{1V}(x, y, W, t)] dW \right\} + k_V(x, y, z, T) V(x, y, z, t) + \\
& \quad + \frac{\partial}{\partial z} \left[D_{\Phi_V}(x, y, z, T) \frac{\partial \Phi_{1V}(x, y, z, t)}{\partial z} \right] + f_{\Phi_V}(x, y, z) \delta(t).
\end{aligned}$$

Integration on the left and the right sides of the Eqs. (1d), (3d) and (5d) gives us possibility to obtain relations for the required concentrations in the final form

$$C_2(x, y, z, t) = \frac{\partial}{\partial x} \int_0^t \left\{ 1 + \xi \frac{[\alpha_{2C} + C_1(x, y, z, \tau)]^\gamma}{P^\gamma(x, y, z, T)} \right\} \left[1 + \varsigma_1 \frac{V(x, y, z, \tau)}{V^*} + \varsigma_2 \frac{V^2(x, y, z, \tau)}{(V^*)^2} \right] \times$$

$$\begin{aligned}
& \times D_L(x, y, z, T) \frac{\partial C_1(x, y, z, \tau)}{\partial x} d\tau + \frac{\partial}{\partial y} \int_0^t D_L(x, y, z, T) \left[1 + \zeta_1 \frac{V(x, y, z, \tau)}{V^*} + \zeta_2 \frac{V^2(x, y, z, \tau)}{(V^*)^2} \right] \times \\
& \times \frac{\partial C_1(x, y, z, \tau)}{\partial y} \left\{ 1 + \xi \frac{[\alpha_{2C} + C_1(x, y, z, t)]^\gamma}{P^\gamma(x, y, z, T)} \right\} + \frac{\partial}{\partial z} \int_0^t \left[1 + \zeta_1 \frac{V(x, y, z, \tau)}{V^*} + \zeta_2 \frac{V^2(x, y, z, \tau)}{(V^*)^2} \right] \times \\
& \times D_L(x, y, z, T) \frac{\partial C_1(x, y, z, \tau)}{\partial z} \left\{ 1 + \xi \frac{[\alpha_{2C} + C_1(x, y, z, \tau)]^\gamma}{P^\gamma(x, y, z, T)} \right\} d\tau + f_C(x, y, z) + \\
& + \Omega \frac{\partial}{\partial x} \int_0^t \frac{D_s}{kT} \nabla_s \mu(x, y, z, \tau) \int_0^{L_z} [\alpha_{2C} + C_1(x, y, W, \tau)] dW d\tau + \frac{\partial}{\partial y} \int_0^t \nabla_s \mu(x, y, z, \tau) \times \\
& \times \Omega \frac{D_s}{kT} \int_0^{L_z} [\alpha_{2C} + C_1(x, y, W, \tau)] dW d\tau \quad (1e)
\end{aligned}$$

$$\begin{aligned}
I_2(x, y, z, t) &= \frac{\partial}{\partial x} \int_0^t D_I(x, y, z, T) \frac{\partial I_1(x, y, z, \tau)}{\partial x} d\tau + \frac{\partial}{\partial y} \int_0^t D_I(x, y, z, T) \frac{\partial I_1(x, y, z, \tau)}{\partial y} d\tau + \\
& + \frac{\partial}{\partial z} \int_0^t D_I(x, y, z, T) \frac{\partial I_1(x, y, z, \tau)}{\partial z} d\tau - \int_0^t k_{I,I}(x, y, z, T) [\alpha_{2I} + I_1(x, y, z, \tau)]^2 d\tau - \\
& - \int_0^t k_{I,V}(x, y, z, T) [\alpha_{2I} + I_1(x, y, z, \tau)] [\alpha_{2V} + V_1(x, y, z, \tau)] d\tau + \frac{\partial}{\partial x} \int_0^t \nabla_s \mu(x, y, z, \tau) \times \\
& \times \Omega \frac{D_{IS}}{kT} \int_0^{L_z} [\alpha_{2I} + I_1(x, y, W, \tau)] dW d\tau + \frac{\partial}{\partial y} \int_0^t \nabla_s \mu(x, y, z, \tau) \int_0^{L_z} [\alpha_{2I} + I_1(x, y, W, \tau)] \times \\
& \times \Omega \frac{D_{IS}}{kT} dW d\tau \quad (3e)
\end{aligned}$$

$$\begin{aligned}
V_2(x, y, z, t) &= \frac{\partial}{\partial x} \int_0^t D_V(x, y, z, T) \frac{\partial V_1(x, y, z, \tau)}{\partial x} d\tau + \frac{\partial}{\partial y} \int_0^t D_V(x, y, z, T) \frac{\partial V_1(x, y, z, \tau)}{\partial y} d\tau + \\
& + \frac{\partial}{\partial z} \int_0^t D_V(x, y, z, T) \frac{\partial V_1(x, y, z, \tau)}{\partial z} d\tau - \int_0^t k_{V,V}(x, y, z, T) [\alpha_{2V} + V_1(x, y, z, \tau)]^2 d\tau - \\
& - \int_0^t k_{I,V}(x, y, z, T) [\alpha_{2I} + I_1(x, y, z, \tau)] [\alpha_{2V} + V_1(x, y, z, \tau)] d\tau + \frac{\partial}{\partial x} \int_0^t \nabla_s \mu(x, y, z, \tau) \times \\
& \times \Omega \frac{D_{VS}}{kT} \int_0^{L_z} [\alpha_{2V} + V_1(x, y, W, \tau)] dW d\tau + \frac{\partial}{\partial y} \int_0^t \nabla_s \mu(x, y, z, \tau) \int_0^{L_z} [\alpha_{2V} + V_1(x, y, W, \tau)] \times
\end{aligned}$$

$$\begin{aligned}
& \times \Omega \frac{D_{VS}}{kT} dW d\tau + f_v(x, y, z) \\
\Phi_{2I}(x, y, z, t) &= \frac{\partial}{\partial x} \int_0^t D_{\Phi_I}(x, y, z, T) \frac{\partial \Phi_{1I}(x, y, z, \tau)}{\partial x} d\tau + \frac{\partial}{\partial y} \int_0^t \frac{\partial \Phi_{1I}(x, y, z, \tau)}{\partial y} \times \\
& \times D_{\Phi_I}(x, y, z, T) d\tau + \frac{\partial}{\partial z} \int_0^t D_{\Phi_I}(x, y, z, T) \frac{\partial \Phi_{1I}(x, y, z, \tau)}{\partial z} d\tau + \Omega \frac{\partial}{\partial x} \int_0^t \nabla_s \mu(x, y, z, \tau) \times \\
& \times \frac{D_{\Phi_{IS}}}{kT} \int_0^{L_z} [\alpha_{2\Phi_I} + \Phi_{1I}(x, y, W, \tau)] dW d\tau + \Omega \frac{\partial}{\partial y} \int_0^t \frac{D_{\Phi_{IS}}}{kT} \int_0^{L_z} [\alpha_{2\Phi_I} + \Phi_{1I}(x, y, W, \tau)] dW \times \\
& \times \nabla_s \mu(x, y, z, \tau) d\tau + \int_0^t k_{I,I}(x, y, z, T) I^2(x, y, z, \tau) d\tau + \int_0^t k_I(x, y, z, T) I(x, y, z, \tau) d\tau + \\
& + f_{\Phi_I}(x, y, z) \quad (5e) \\
\Phi_{2V}(x, y, z, t) &= \frac{\partial}{\partial x} \int_0^t D_{\Phi_V}(x, y, z, T) \frac{\partial \Phi_{1V}(x, y, z, \tau)}{\partial x} d\tau + \frac{\partial}{\partial y} \int_0^t \frac{\partial \Phi_{1V}(x, y, z, \tau)}{\partial y} \times \\
& \times D_{\Phi_V}(x, y, z, T) d\tau + \frac{\partial}{\partial z} \int_0^t D_{\Phi_V}(x, y, z, T) \frac{\partial \Phi_{1V}(x, y, z, \tau)}{\partial z} d\tau + \Omega \frac{\partial}{\partial x} \int_0^t \nabla_s \mu(x, y, z, \tau) \times \\
& \times \frac{D_{\Phi_{VS}}}{kT} \int_0^{L_z} [\alpha_{2\Phi_V} + \Phi_{1V}(x, y, W, \tau)] dW d\tau + \Omega \frac{\partial}{\partial y} \int_0^t \frac{D_{\Phi_{VS}}}{kT} \int_0^{L_z} [\alpha_{2\Phi_V} + \Phi_{1V}(x, y, W, \tau)] dW \times \\
& \times \nabla_s \mu(x, y, z, \tau) d\tau + \int_0^t k_{V,V}(x, y, z, T) V^2(x, y, z, \tau) d\tau + \int_0^t k_V(x, y, z, T) V(x, y, z, \tau) d\tau + \\
& + f_{\Phi_V}(x, y, z).
\end{aligned}$$

Average values of the second-order approximations of required approximations by using the following standard relation [26]

$$\alpha_{2\rho} = \frac{1}{\Theta L_x L_y L_z} \int_0^{\Theta} \int_0^{L_x} \int_0^{L_y} \int_0^{L_z} [\rho_2(x, y, z, t) - \rho_1(x, y, z, t)] dz dy dx dt. \quad (10)$$

Substitution of the relations (1e), (3e), (5e) into relation (10) gives us possibility to obtain relations for required average values $\alpha_{2\rho}$

$$\alpha_{2C}=0, \alpha_{2\Phi_I}=0, \alpha_{2\Phi_V}=0, \alpha_{2V} = \sqrt{\frac{(b_3 + E)^2}{4b_4^2} - 4 \left(F + \frac{\Theta a_3 F + \Theta^2 L_x L_y L_z b_1}{b_4} \right)} - \frac{b_3 + E}{4b_4},$$

$$\alpha_{2I} = \frac{C_V - \alpha_{2V}^2 S_{VV00} - \alpha_{2V} (2S_{VV01} + S_{IV10} + \Theta L_x L_y L_z) - S_{VV02} - S_{IV11}}{S_{IV01} + \alpha_{2V} S_{IV00}},$$

$$\text{where } b_4 = \frac{1}{\Theta L_x L_y L_z} S_{IV00}^2 S_{VV00} - \frac{1}{\Theta L_x L_y L_z} S_{VV00}^2 S_{II00},$$

$$\begin{aligned} b_3 = & -\frac{S_{II00} S_{VV00}}{\Theta L_x L_y L_z} (2S_{VV01} + S_{IV10} + \\ & + \Theta L_x L_y L_z) + \frac{S_{IV00} S_{VV00}}{\Theta L_x L_y L_z} (S_{IV01} + 2S_{II10} + S_{IV01} + \Theta L_x L_y L_z) + \frac{S_{IV00}^2}{\Theta L_x L_y L_z} (2S_{VV01} + S_{IV10} + \\ & + \Theta L_x L_y L_z) - \frac{S_{IV00}^2 S_{IV10}}{\Theta^3 L_x^3 L_y^3 L_z^3}, \\ b_2 = & \frac{S_{II00} S_{VV00}}{\Theta L_x L_y L_z} (S_{VV02} + S_{IV11} + C_V) - (S_{IV10} - 2S_{VV01} + \Theta L_x L_y \times \\ & \times L_z)^2 + \frac{S_{IV01} S_{VV00}}{\Theta L_x L_y L_z} (\Theta L_x L_y L_z + 2S_{II10} + S_{IV01}) + \frac{S_{IV00}}{\Theta L_x L_y L_z} (S_{IV01} + 2S_{II10} + 2S_{IV01} + \Theta L_x L_y \times \\ & \times L_z) (2S_{VV01} + \Theta L_x L_y L_z + S_{IV10}) - \frac{S_{IV00}^2}{\Theta L_x L_y L_z} (C_V - S_{VV02} - S_{IV11}) + \frac{C_I S_{IV00}^2}{\Theta^2 L_x^2 L_y^2 L_z^2} - \frac{2S_{IV10}}{\Theta L_x L_y L_z} \times \\ & \times S_{IV00} S_{IV01}, \\ b_1 = & S_{II00} \frac{S_{IV11} + S_{VV02} + C_V}{\Theta L_x L_y L_z} (2S_{VV01} + S_{IV10} + \Theta L_x L_y L_z) + \frac{S_{IV01}}{\Theta L_x L_y L_z} (\Theta L_x L_y \times \\ & \times L_z + 2S_{II10} + S_{IV01}) (2S_{VV01} + S_{IV10} + \Theta L_x L_y L_z) - \frac{S_{IV10} S_{IV01}^2}{\Theta L_x L_y L_z} - \frac{S_{IV00}}{\Theta L_x L_y L_z} (3S_{IV01} + 2S_{II10} + \\ & + \Theta L_x L_y L_z) (C_V - S_{VV02} - S_{IV11}) + 2C_I S_{IV00} S_{IV01}, \\ b_0 = & \frac{S_{II00}}{\Theta L_x L_y L_z} (S_{IV00} + S_{VV02})^2 - \frac{S_{IV01}}{L_x L_y L_z} \times \\ & \times \frac{1}{\Theta} (\Theta L_x L_y L_z + 2S_{II10} + S_{IV01}) (C_V - S_{VV02} - S_{IV11}) + 2C_I S_{IV01}^2 - S_{IV01} \frac{C_V - S_{VV02} - S_{IV11}}{\Theta L_x L_y L_z} \times \end{aligned}$$

$$\begin{aligned}
& \times (\Theta L_x L_y L_z + 2 S_{II10} + S_{IV01}), \\
C_I &= \frac{\alpha_{1I} \alpha_{1V}}{\Theta L_x L_y L_z} S_{IV00} + \frac{\alpha_{1I}^2 S_{II00}}{\Theta L_x L_y L_z} - \frac{S_{II20} S_{II20}}{\Theta L_x L_y L_z} - \frac{S_{IV11}}{\Theta L_x L_y L_z}, \\
C_V &= \alpha_{1I} \alpha_{1V} S_{IV00} + \alpha_{1V}^2 S_{VV00} - S_{VV02} - S_{IV11}, \quad E = \sqrt{8y + \Theta^2 \frac{a_3^2}{a_4^2} - 4\Theta \frac{a_2}{a_4}}, \quad F = \frac{\Theta a_2}{6a_4} + \\
& + \sqrt[3]{\sqrt{r^2 + s^3} - r} - \sqrt[3]{\sqrt{r^2 + s^3} + r}, \\
r &= \frac{\Theta^3 b_2}{24b_4^2} \left(4b_0 - \Theta L_x L_y L_z \frac{b_1 b_3}{b_4} \right) - \frac{\Theta^3 b_2^3}{54b_4^3} - b_0 \frac{\Theta^2}{8b_4^2} \times \\
& \times \left(4\Theta b_2 - \Theta^2 \frac{b_3^2}{b_4} \right) - L_x^2 L_y^2 L_z^2 \frac{\Theta^4 b_1^2}{8b_4^2}, \quad s = \Theta^2 \frac{4b_0 b_4 - \Theta L_x L_y L_z b_1 b_3}{12b_4^2} - \frac{\Theta b_2}{18b_4}.
\end{aligned}$$

Further we determine solutions of Eqs.(8), i.e. components of displacement vector. To determine the first-order approximations of the considered components framework method of averaging of function corrections we replace the required functions in the right sides of the equations by their not yet known average values α_i . The substitution leads to the following result

$$\begin{aligned}
\rho(z) \frac{\partial^2 u_{1x}(x, y, z, t)}{\partial t^2} &= -K(z) \beta(z) \frac{\partial T(x, y, z, t)}{\partial x}, \quad \rho(z) \frac{\partial^2 u_{1y}(x, y, z, t)}{\partial t^2} = \\
&= -K(z) \beta(z) \frac{\partial T(x, y, z, t)}{\partial y}, \quad \rho(z) \frac{\partial^2 u_{1z}(x, y, z, t)}{\partial t^2} = -K(z) \beta(z) \frac{\partial T(x, y, z, t)}{\partial z}.
\end{aligned}$$

Integration of the left and the right sides of the above relations on time t leads to the following result

$$\begin{aligned}
u_{1x}(x, y, z, t) &= u_{0x} + K(z) \frac{\beta(z)}{\rho(z)} \frac{\partial}{\partial x} \int_0^t \int_0^g T(x, y, z, \tau) d\tau d\vartheta - \\
&\quad - K(z) \frac{\beta(z)}{\rho(z)} \frac{\partial}{\partial x} \int_0^\infty \int_0^g T(x, y, z, \tau) d\tau d\vartheta, \\
u_{1y}(x, y, z, t) &= u_{0y} + K(z) \frac{\beta(z)}{\rho(z)} \frac{\partial}{\partial y} \int_0^t \int_0^g T(x, y, z, \tau) d\tau d\vartheta - \\
&\quad - K(z) \frac{\beta(z)}{\rho(z)} \frac{\partial}{\partial y} \int_0^\infty \int_0^g T(x, y, z, \tau) d\tau d\vartheta, \\
u_{1z}(x, y, z, t) &= u_{0z} + K(z) \frac{\beta(z)}{\rho(z)} \frac{\partial}{\partial z} \int_0^t \int_0^g T(x, y, z, \tau) d\tau d\vartheta - \\
&\quad - K(z) \frac{\beta(z)}{\rho(z)} \frac{\partial}{\partial z} \int_0^\infty \int_0^g T(x, y, z, \tau) d\tau d\vartheta.
\end{aligned}$$

Approximations of the second and higher orders of components of displacement vector could be determined by using standard replacement of the required components on the following sums $\alpha_i + u_i(x, y, z, t)$ [26]. The replacement leads to the following result

$$\begin{aligned} \rho(z) \frac{\partial^2 u_{2x}(x, y, z, t)}{\partial t^2} &= \left\{ K(z) + \frac{5E(z)}{6[1+\sigma(z)]} \right\} \frac{\partial^2 u_{1x}(x, y, z, t)}{\partial x^2} + \left\{ K(z) - \frac{E(z)}{3[1+\sigma(z)]} \right\} \times \\ &\times \frac{\partial^2 u_{1y}(x, y, z, t)}{\partial x \partial y} + \frac{E(z)}{2[1+\sigma(z)]} \left[\frac{\partial^2 u_{1y}(x, y, z, t)}{\partial y^2} + \frac{\partial^2 u_{1z}(x, y, z, t)}{\partial z^2} \right] - \frac{\partial T(x, y, z, t)}{\partial x} \times \\ &\times K(z) \beta(z) + \left\{ K(z) + \frac{E(z)}{3[1+\sigma(z)]} \right\} \frac{\partial^2 u_{1z}(x, y, z, t)}{\partial x \partial z} \\ \rho(z) \frac{\partial^2 u_{2y}(x, y, z, t)}{\partial t^2} &= \frac{E(z)}{2[1+\sigma(z)]} \left[\frac{\partial^2 u_{1y}(x, y, z, t)}{\partial x^2} + \frac{\partial^2 u_{1x}(x, y, z, t)}{\partial x \partial y} \right] - \frac{\partial T(x, y, z, t)}{\partial y} \times \\ &\times K(z) \beta(z) + \frac{\partial}{\partial z} \left\{ \frac{E(z)}{2[1+\sigma(z)]} \left[\frac{\partial u_{1y}(x, y, z, t)}{\partial z} + \frac{\partial u_{1z}(x, y, z, t)}{\partial y} \right] \right\} + \frac{\partial^2 u_{1y}(x, y, z, t)}{\partial y^2} \times \\ &\times \left\{ \frac{5E(z)}{12[1+\sigma(z)]} + K(z) \right\} + \left\{ K(z) - \frac{E(z)}{6[1+\sigma(z)]} \right\} \frac{\partial^2 u_{1y}(x, y, z, t)}{\partial y \partial z} + K(z) \frac{\partial^2 u_{1y}(x, y, z, t)}{\partial x \partial y} \\ \rho(z) \frac{\partial^2 u_{2z}(x, y, z, t)}{\partial t^2} &= \frac{E(z)}{2[1+\sigma(z)]} \left[\frac{\partial^2 u_{1z}(x, y, z, t)}{\partial x^2} + \frac{\partial^2 u_{1z}(x, y, z, t)}{\partial y^2} + \frac{\partial^2 u_{1x}(x, y, z, t)}{\partial x \partial z} + \right. \\ &+ \left. \frac{\partial^2 u_{1y}(x, y, z, t)}{\partial y \partial z} \right] + \frac{\partial}{\partial z} \left\{ K(z) \left[\frac{\partial u_{1x}(x, y, z, t)}{\partial x} + \frac{\partial u_{1y}(x, y, z, t)}{\partial y} + \frac{\partial u_{1z}(x, y, z, t)}{\partial z} \right] \right\} + \\ &+ \frac{E(z)}{6[1+\sigma(z)]} \frac{\partial}{\partial z} \left[6 \frac{\partial u_{1z}(x, y, z, t)}{\partial z} - \frac{\partial u_{1x}(x, y, z, t)}{\partial x} - \frac{\partial u_{1y}(x, y, z, t)}{\partial y} - \frac{\partial u_{1z}(x, y, z, t)}{\partial z} \right] - \\ &- \frac{\partial u_{1x}(x, y, z, t)}{\partial x} - \frac{\partial u_{1y}(x, y, z, t)}{\partial y} - \frac{\partial u_{1z}(x, y, z, t)}{\partial z} \left\{ \frac{E(z)}{1+\sigma(z)} - K(z) \beta(z) \frac{\partial T(x, y, z, t)}{\partial z} \right\} \end{aligned}$$

Integration of the left and right sides of the above relations on time t leads to the following result

$$u_{2x}(x, y, z, t) = \frac{1}{\rho(z)} \left\{ K(z) + \frac{5E(z)}{6[1+\sigma(z)]} \right\} \frac{\partial^2}{\partial x^2} \int_0^t \int_0^g u_{1x}(x, y, z, \tau) d\tau d\vartheta + \frac{1}{\rho(z)} \left\{ K(z) - \right.$$

$$\begin{aligned}
& -\frac{E(z)}{3[1+\sigma(z)]}\left\{\frac{\partial^2}{\partial x \partial y} \int_0^t \int_0^g u_{1y}(x, y, z, \tau) d\tau d\vartheta + \frac{E(z)}{2\rho(z)}\left[\frac{\partial^2}{\partial y^2} \int_0^t \int_0^g u_{1y}(x, y, z, \tau) d\tau d\vartheta + \right.\right. \\
& \left. + \frac{\partial^2}{\partial z^2} \int_0^t \int_0^g u_{1z}(x, y, z, \tau) d\tau d\vartheta\right]\frac{1}{1+\sigma(z)} + \frac{1}{\rho(z)}\frac{\partial^2}{\partial x \partial z} \int_0^t \int_0^g u_{1z}(x, y, z, \tau) d\tau d\vartheta\left\{K(z) + \right. \\
& \left. + \frac{E(z)}{3[1+\sigma(z)]}\right\} - K(z)\frac{\beta(z)}{\rho(z)}\frac{\partial}{\partial x} \int_0^t \int_0^g T(x, y, z, \tau) d\tau d\vartheta - \frac{\partial^2}{\partial x^2} \int_0^t \int_0^g u_{1x}(x, y, z, \tau) d\tau d\vartheta \times \\
& \times \frac{1}{\rho(z)}\left\{K(z) + \frac{5E(z)}{6[1+\sigma(z)]}\right\} - \left\{K(z) - \frac{E(z)}{3[1+\sigma(z)]}\right\}\frac{\partial^2}{\partial x \partial y} \int_0^t \int_0^g u_{1y}(x, y, z, \tau) d\tau d\vartheta \times \\
& \times \frac{1}{\rho(z)} - \frac{E(z)}{2\rho(z)[1+\sigma(z)]}\left[\frac{\partial^2}{\partial y^2} \int_0^t \int_0^g u_{1y}(x, y, z, \tau) d\tau d\vartheta + \frac{\partial^2}{\partial z^2} \int_0^t \int_0^g u_{1z}(x, y, z, \tau) d\tau d\vartheta\right] - \\
& - \frac{1}{\rho(z)}\left\{K(z) + \frac{E(z)}{3[1+\sigma(z)]}\right\}\frac{\partial^2}{\partial x \partial z} \int_0^t \int_0^g u_{1z}(x, y, z, \tau) d\tau d\vartheta + u_{0x} + K(z)\frac{\beta(z)}{\rho(z)} \times \\
& \times \frac{\partial}{\partial x} \int_0^t \int_0^g T(x, y, z, \tau) d\tau d\vartheta \\
u_{2y}(x, y, z, t) = & \frac{E(z)}{2\rho(z)}\left[\frac{\partial^2}{\partial x^2} \int_0^t \int_0^g u_{1x}(x, y, z, \tau) d\tau d\vartheta + \frac{\partial^2}{\partial x \partial y} \int_0^t \int_0^g u_{1x}(x, y, z, \tau) d\tau d\vartheta\right] \times \\
& \times \frac{1}{1+\sigma(z)} + \frac{K(z)}{\rho(z)}\frac{\partial^2}{\partial x \partial y} \int_0^t \int_0^g u_{1y}(x, y, z, \tau) d\tau d\vartheta + \frac{1}{\rho(z)}\left\{\frac{5E(z)}{12[1+\sigma(z)]} + K(z)\right\} \times \\
& \times \frac{\partial^2}{\partial y^2} \int_0^t \int_0^g u_{1x}(x, y, z, \tau) d\tau d\vartheta + \frac{1}{2\rho(z)}\frac{\partial}{\partial z}\left\{\frac{E(z)}{1+\sigma(z)}\left[\frac{\partial}{\partial z} \int_0^t \int_0^g u_{1y}(x, y, z, \tau) d\tau d\vartheta + \right.\right. \\
& \left. + \frac{\partial}{\partial y} \int_0^t \int_0^g u_{1z}(x, y, z, \tau) d\tau d\vartheta\right]\left\} - K(z)\frac{\beta(z)}{\rho(z)}\int_0^t \int_0^g T(x, y, z, \tau) d\tau d\vartheta - \left\{\frac{E(z)}{6[1+\sigma(z)]} - \right.\right. \\
& \left. - K(z)\right\}\frac{1}{\rho(z)}\frac{\partial^2}{\partial y \partial z} \int_0^t \int_0^g u_{1y}(x, y, z, \tau) d\tau d\vartheta - \frac{E(z)}{2\rho(z)}\left[\frac{\partial^2}{\partial x^2} \int_0^t \int_0^g u_{1x}(x, y, z, \tau) d\tau d\vartheta + \right.
\end{aligned}$$

$$\begin{aligned}
& + \frac{\partial^2}{\partial x \partial y} \int_0^g \int_0^g u_{1x}(x, y, z, \tau) d\tau d\vartheta \left] \frac{1}{1+\sigma(z)} - K(z) \frac{\beta(z)}{\rho(z)} \int_0^g \int_0^g T(x, y, z, \tau) d\tau d\vartheta - \frac{K(z)}{\rho(z)} \times \right. \\
& \times \frac{\partial^2}{\partial x \partial y} \int_0^g \int_0^g u_{1y}(x, y, z, \tau) d\tau d\vartheta - \frac{1}{\rho(z)} \frac{\partial^2}{\partial y^2} \int_0^g \int_0^g u_{1x}(x, y, z, \tau) d\tau d\vartheta \left\{ \frac{5E(z)}{12[1+\sigma(z)]} + \right. \\
& \left. + K(z) \right\} - \frac{\partial}{\partial z} \left\{ \frac{E(z)}{1+\sigma(z)} \left[\frac{\partial}{\partial z} \int_0^g \int_0^g u_{1y}(x, y, z, \tau) d\tau d\vartheta + \frac{\partial}{\partial y} \int_0^g \int_0^g u_{1z}(x, y, z, \tau) d\tau d\vartheta \right] \right\} \times \\
& \times \frac{1}{2\rho(z)} - \frac{1}{\rho(z)} \left\{ K(z) - \frac{E(z)}{6[1+\sigma(z)]} \right\} \frac{\partial^2}{\partial y \partial z} \int_0^g \int_0^g u_{1y}(x, y, z, \tau) d\tau d\vartheta + u_{0y} \\
& u_z(x, y, z, t) = \frac{E(z)}{2[1+\sigma(z)]} \left[\frac{\partial^2}{\partial x^2} \int_0^g \int_0^g u_{1z}(x, y, z, \tau) d\tau d\vartheta + \frac{\partial^2}{\partial y^2} \int_0^g \int_0^g u_{1z}(x, y, z, \tau) d\tau d\vartheta + \right. \\
& \left. + \frac{\partial^2}{\partial x \partial z} \int_0^g \int_0^g u_{1x}(x, y, z, \tau) d\tau d\vartheta + \frac{\partial^2}{\partial y \partial z} \int_0^g \int_0^g u_{1y}(x, y, z, \tau) d\tau d\vartheta \right] \frac{1}{\rho(z)} + \frac{1}{\rho(z)} \times \\
& \times \frac{\partial}{\partial z} \left\{ K(z) \left[\frac{\partial}{\partial x} \int_0^g \int_0^g u_{1x}(x, y, z, \tau) d\tau d\vartheta + \frac{\partial}{\partial y} \int_0^g \int_0^g u_{1x}(x, y, z, \tau) d\tau d\vartheta + \right. \right. \\
& \left. \left. + \frac{\partial}{\partial z} \int_0^g \int_0^g u_{1x}(x, y, z, \tau) d\tau d\vartheta \right] \right\} + \frac{1}{6\rho(z)} \frac{\partial}{\partial z} \left\{ \frac{E(z)}{1+\sigma(z)} \left[6 \frac{\partial}{\partial z} \int_0^g \int_0^g u_{1z}(x, y, z, \tau) d\tau d\vartheta - \right. \right. \\
& \left. \left. - \frac{\partial}{\partial x} \int_0^g \int_0^g u_{1x}(x, y, z, \tau) d\tau d\vartheta - \frac{\partial}{\partial y} \int_0^g \int_0^g u_{1y}(x, y, z, \tau) d\tau d\vartheta - \frac{\partial}{\partial z} \int_0^g \int_0^g u_{1z}(x, y, z, \tau) d\tau d\vartheta \right] \right\} - \\
& - K(z) \frac{\beta(z)}{\rho(z)} \frac{\partial}{\partial z} \int_0^g \int_0^g T(x, y, z, \tau) d\tau d\vartheta + u_{0z}.
\end{aligned}$$

Framework this paper, we determine concentration of dopant, concentrations of radiation defects and components of displacement vector by using the second-order approximation framework method of averaging of function

corrections. This approximation is usually enough good approximation to make qualitative analysis and to obtain some quantitative results. All obtained results have been checked by comparison with results of numerical simulations.

DISCUSSION

In this section, we have analyzed the dynamics of redistributions of dopant and radiation defects during annealing and under influence of mismatch-induced stress. Typical distributions of concentrations of dopant in heterostructures are presented on Figs. 2 and 3 for diffusion and ion

types of doping, respectively. These distributions have been calculated for the case, when value of dopant diffusion coefficient in the epitaxial layer is larger, than in the substrate. The figures show, that inhomogeneity of heterostructure gives us possibility to increase sharpness of p - n - junctions.

At the same time one can find increasing homogeneity of dopant distribution in doped part of epitaxial layer. Increasing of sharpness of p - n -junction gives us possibility to decrease switching time. The second effect leads to decreasing local heating of materials during functioning of p - n -junction or decreasing of dimensions of the p - n -junction for fixed maximal value of local overheat. However framework this approach of manufacturing of bipolar transistor it is necessary to optimize annealing of dopant and/or radiation defects. Reason of this optimization is following. If annealing time is small, the dopant did not achieve

any interfaces between materials of heterostructure. In this situation one cannot find any modifications of distribution of concentration of dopant. If annealing time is large, distribution of concentration of dopant is too homogenous. We optimize annealing time framework recently introduces approach [15,25-32]. Framework this criterion we approximate real distribution of concentration of dopant by step-wise function (see Figs. 4 and 5). Farther we determine optimal values of annealing time by minimization of the following mean-squared error

$$U = \frac{1}{L_x L_y L_z} \int_0^{L_x} \int_0^{L_y} \int_0^{L_z} [C(x, y, z, \Theta) - \psi(x, y, z)] dz dy dx, \quad (15)$$

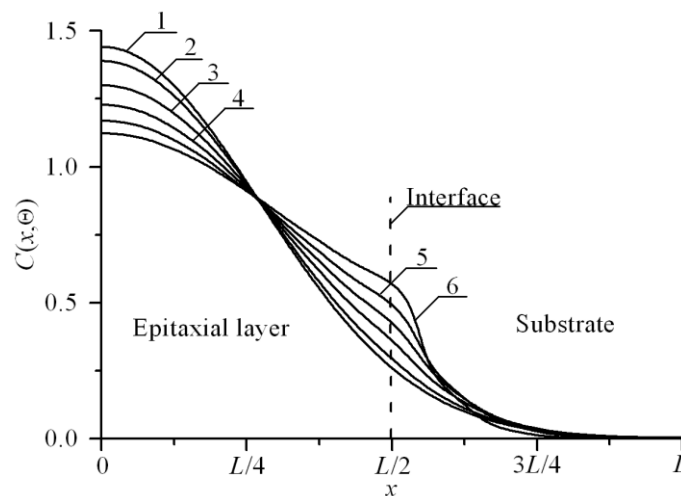


Fig.2. Distributions of concentration of infused dopant in heterostructure from Fig. 1 in direction, which is perpendicular to interface between epitaxial layer substrate. Increasing of number of curve corresponds to increasing of difference between values of dopant diffusion coefficient in layers of heterostructure under condition, when value of dopant diffusion coefficient in epitaxial layer is larger, than value of dopant diffusion coefficient in substrate

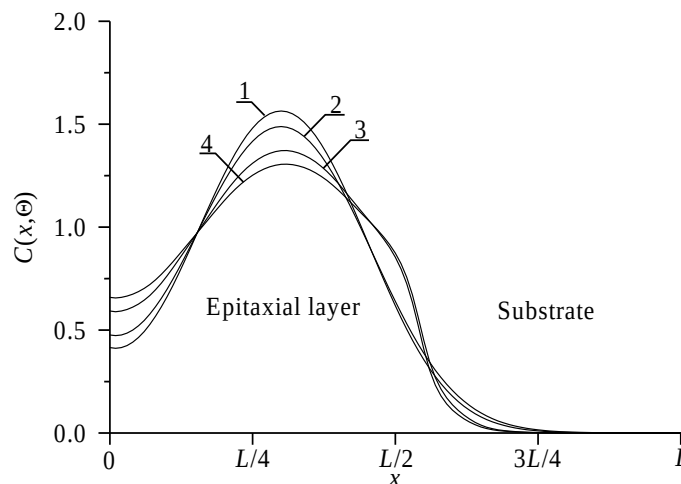


Fig.3. Distributions of concentration of implanted dopant in heterostructure from Fig. 1 in direction, which is perpendicular to interface between epitaxial layer substrate. Curves 1 and 3 corresponds to annealing time $\Theta = 0.0048(L_x^2 + L_y^2 + L_z^2)/D_0$. Curves 2 and 4 corresponds to annealing time $\Theta = 0.0057(L_x^2 + L_y^2 + L_z^2)/D_0$.

Curves 1 and 2 corresponds to homogenous sample. Curves 3 and 4 corresponds to heterostructure under condition, when value of dopant diffusion coefficient in epitaxial layer is larger, than value of dopant diffusion coefficient in substrate

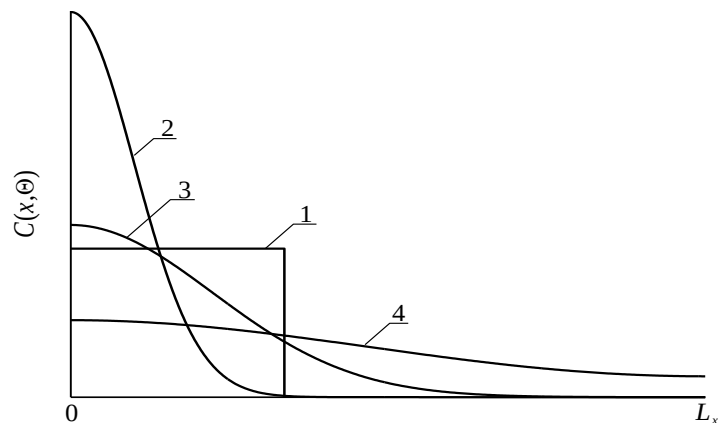


Fig. 4. Spatial distributions of dopant in heterostructure after dopant infusion. Curve 1 is idealized distribution of dopant. Curves 2-4 are real distributions of dopant for different values of annealing time. Increasing of number of curve corresponds to increasing of annealing time

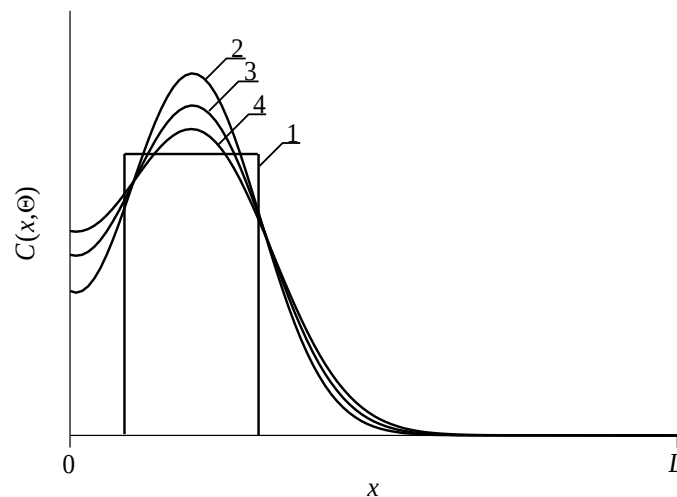
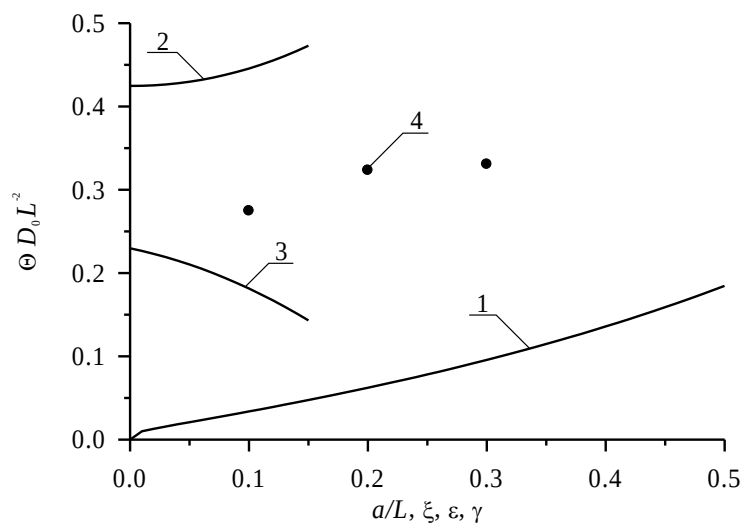


Fig. 5. Spatial distributions of dopant in heterostructure after ion implantation. Curve 1 is idealized distribution of dopant. Curves 2-4 are real distributions of dopant for different values of annealing time. Increasing of number of curve corresponds to increasing of annealing time



Pankratov

Fig.6. Dependences of dimensionless optimal annealing time for doping by diffusion, which have been obtained by minimization of mean-squared error, on several parameters. Curve 1 is the dependence of dimensionless optimal annealing time on the relation a/L and $\xi = \gamma = 0$ for equal to each other values of dopant diffusion coefficient in all parts of heterostructure. Curve 2 is the dependence of dimensionless optimal annealing time on value of parameter ε for $a/L=1/2$ and $\xi = \gamma = 0$. Curve 3 is the dependence of dimensionless optimal annealing time on value of parameter ξ for $a/L=1/2$ and $\varepsilon = \gamma = 0$. Curve 4 is the dependence of dimensionless optimal annealing time on value of parameter γ for $a/L=1/2$ and $\varepsilon = \xi = 0$

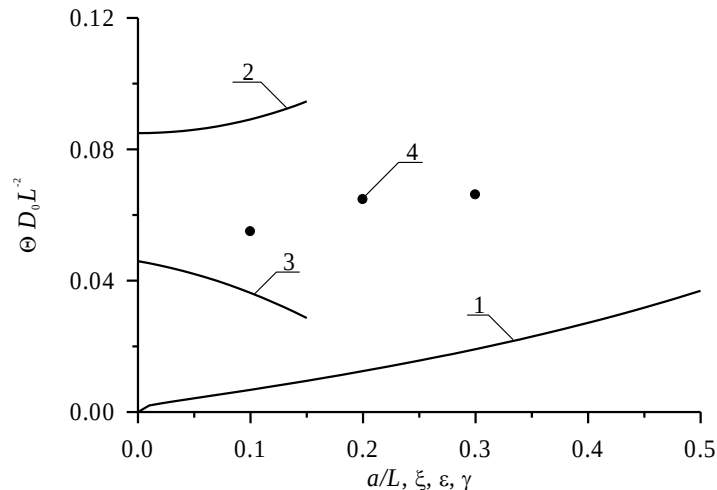


Fig.7. Dependences of dimensionless optimal annealing time for doping by ion implantation, which have been obtained by minimization of mean-squared error, on several parameters. Curve 1 is the dependence of dimensionless optimal annealing time on the relation a/L and $\xi = \gamma = 0$ for equal to each other values of dopant diffusion coefficient in all parts of heterostructure. Curve 2 is the dependence of dimensionless optimal annealing time on value of parameter ε for $a/L=1/2$ and $\xi = \gamma = 0$. Curve 3 is the dependence of dimensionless optimal annealing time on value of parameter ξ for $a/L=1/2$ and $\varepsilon = \gamma = 0$. Curve 4 is the dependence of dimensionless optimal annealing time on value of parameter γ for $a/L=1/2$ and $\varepsilon = \xi = 0$

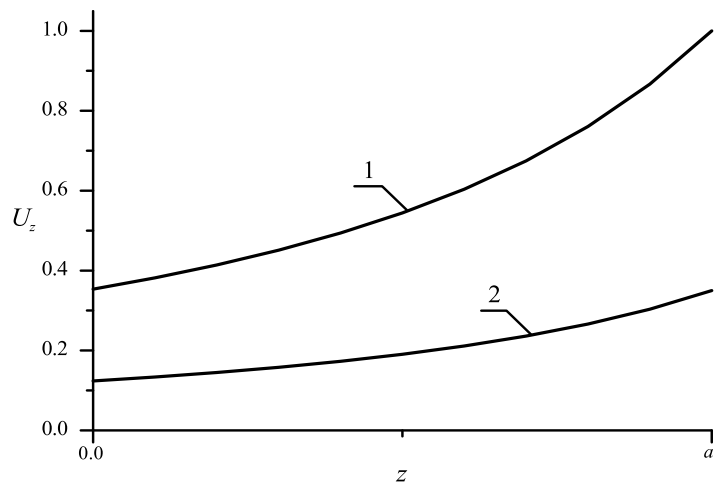


Fig. 8. Normalized dependences of component u_z of displacement vector on coordinate z for nonporous (curve 1) and porous (curve 2) epitaxial layers

where $\psi(x,y,z)$ is the approximation function. Dependences of optimal values of annealing time on parameters are presented on Figs. 6 and 7 for diffusion and ion types of doping, respectively. It should be noted, that it is necessary to anneal radiation defects after ion implantation. One could find spreading of concentration of distribution of

dopant during this annealing. In the ideal case distribution of dopant achieves appropriate interfaces between materials of heterostructure during annealing of radiation defects. If dopant did not achieves any interfaces during annealing of radiation defects, it is practically to additionally anneal the dopant. In this situation optimal value

of additional annealing time of implanted dopant is smaller, than annealing time of infused dopant.

Further we analyzed influence of relaxation of mechanical stress on distribution of dopant in doped areas of heterostructure. Under following condition $\varepsilon_0 < 0$ one can find compression of distribution of concentration of dopant near interface between materials of heterostructure. Contrary (at $\varepsilon_0 > 0$) one can find spreading of distribution of concentration of dopant in this area. This changing of distribution of concentration of dopant could be at least partially compensated by using laser annealing [29]. This type of annealing gives us possibility to accelerate diffusion of dopant and other processes in annealed area due to inhomogenous distribution of temperature and Arrhenius law. Accounting relaxation of mismatch-induced stress in heterostructure could leads to changing of optimal values of annealing time. Mismatch-induced stress could be used to increase density of elements of

integrated circuits. On the other hand could leads to generation dislocations of the discrepancy. Fig. 8 shows distributions of component of displacement vector, which is perpendicular to interface between layers of heterostructure.

CONCLUSION

In this paper, we modeled the redistribution of infused and implanted dopants with account relaxation mismatch-induced stress during manufacturing field-effect heterotransistors framework an instrumentation amplifier input bias circuitry. Some recommendations to optimize annealing for decreasing of dimensions of the considered transistors, with increase their density. We provided recommendations to decrease mismatch-induced stress. Analytical approach to model diffusion and ion types of doping with account concurrent changing of parameters in space and time has been introduced. At the same time the approach gives us possibility to take into account nonlinearity of considered processes

REFERENCES

- [1] Lachin, V.I., Savelov, N.S. *Electronics* (Rostov-on-Don: Phoenix, 2001).
- [2] Polishcuk, A. (2004). Anadigm Programmable Analog ICs: The entire spectrum of analog electronics on a single chip. First meeting. Modern Electronics. Issue 12. P. 8-11.
- [3] Volovich, G. (2006). Modern chips UM3Ch class D manufactured by firm MPS. Modern Electronics. Issue 2. P. 10-17.
- [4] Kerentsev, A., Lanin, V. (2008). Constructive-technological features of MOSFET -transistors. Power Electronics. Issue 1. P. 34.
- [5] Ageev, A.O., Belyaev, A.E., Boltovets, N.S., Ivanov, V.N., Konakova, R.V., Kudrik, Ya.Ya., Litvin, P.M., Milenin, V.V., Sachenko, A.V. (2009). Au-TiB_x-n-6H-SiC Schottky barrier diodes: the features of current flow in rectifying and nonrectifying contacts. Semiconductors, 43 (7), 897-903.
- [6] Tsai, J.-H., Chiu, Sh.-Y., Lour, W.-Sh., Guo, D.-F. (2009). High-performance InGaP/GaAs pnp δ -doped heterojunctionbipolar transistor. Semiconductors. 43 (7), 971-974.
- [7] Alexandrov, O.V., Zakhar'in, A.O., Sobolev, N.A., Shek, E.I., Makoviychuk, M.M., Parshin, E.O. (1998). Formation of donor centers after annealing of dysprosium and holmium implanted silicon. Semiconductors, 32 (9), 1029-1032.
- [8] Ermolovich, I.B., Milenin, V.V., Red'ko, R.A., Red'ko, S.M. (2009). Specific features of recombination processes in CdTe films produced in different temperature conditions of growth and subsequent annealingю Semiconductors. 43 (8), 980-984.
- [9] Sinsermsuksakul, P. Hartman, K. Kim, S.B. Heo, J. Sun, L. Park, H.H. Chakraborty, R. Buonassisi, T. Gordon R.G. 2013. Enhancing the efficiency of SnS solar cells via band-offset engineering with a zinc oxysulfide buffer layer. Appl. Phys. Lett., 102 (5), 053901-053905.
- [10] Reynolds, J.G., Reynolds, C.L., Mohanta, Jr.A., Muth, J.F., Rowe, J.E., Everitt, H.O., Aspnes D.E. (2013). Shallow acceptor complexes in p-type ZnO. Appl. Phys. Lett. 102 (15). P. 152114-152118.
- [11] Volokobinskaya, N.I., Komarov, I.N., Matyukhina, T.V., Reshetnikov, V.I., Rush, A.A., Falina, I.V., Yastrebov, A.S. (2001). A study of technological processes in the production of high-power high-voltage bipolar transistors incorporating an array of inclusions in the collector region. Semiconductors. 35 (8), 974-978.
- [12] Pankratov, E.L., Bulaeva, E.A. (2013). Doping of materials during manufacture p-n-junctions and bipolar transistors. Analytical approaches to model technological approaches and ways of optimization of distributions of dopants. Reviews in theoretical science. 1 (1), 58-82.
- [13] Kukushkin, S.A., Osipov, A.V., Romanychev, A.I. (2016). Epitaxial growth of zinc oxide by the method of atomic layer deposition on SiC/Si substrates. Physics of the solid state. 58 (7), 1448-1452.

- [14] Trukhanov, E.M., Kolesnikov, A.V., Loshkarev, I.D. (2015). Long-range stresses generated by misfit dislocations in epitaxial films. *Russian Microelectronics*. 44 (8), 552-558.
- [15] Pankratov, E.L., Bulaeva, E.A. On optimization of regimes of epitaxy from gas phase. some analytical approaches to model physical processes in reactors for epitaxy from gas phase during growth films (2015). *Reviews in Theoretical Science*. 3 (4), 365-398.
- [16] Ong, K.K. Pey, K.L. Lee, P.S. Wee, A.T.S. Wang, X.C. Chong. Y.F. (2006). Dopant distribution in the recrystallization transient at the maximum melt depth induced by laser annealing. *Appl. Phys. Lett.*, 89 (17), 172111-172114.
- [17] Wang, H.T. Tan, L.S. Chor. E.F. 2006. Pulsed laser annealing of Be-implanted GaN. *J. Appl. Phys.*, 98 (9), 094901-094905.
- [18] Bykov, Yu.V. Yermeev, A.G. Zharova, N.A. Plotnikov, I.V. Rybakov, K.I. Drozdov, M.N. Yu.N. Drozdov, Skupov. V.D. (2003). Diffusion processes in semiconductor structures during microwave annealing. *Radiophysics and Quantum Electronics*, 43 (3), 836-843.
- [19] Zhang, Y.W., Bower, A.F. (1999). Numerical simulation of island formation in a coherent strained epitaxial thin film systems. *Journal of the Mechanics and Physics of Solids*, 47 (11), 2273-2297.
- [20] Landau, L.D., Lifshits, E.M. *Theoretical physics. 7 (Theory of elasticity)* (Physmatlit, Moscow, 2001).
- [21] Gotra, Z.Yu. *Technology of microelectronic devices* (Radio and communication, Moscow, 1991).
- [22] Fahey, P.M., Griffin, P.B., Plummer, J.D. (1989). Point defects and dopant diffusion in silicon. *Rev. Mod. Phys.*, 61 (2), 289-388.
- [23] Vinetskiy, V.L., Kholodar', G.A. *Radiative physics of semiconductors*. ("Naukova Dumka", Kiev, 1979).
- [24] Chang, C., Xu, L., Onabajo, M. (2016). Instrumentation amplifier and current injection circuit design for input impedance boosting in biopotential and bioimpedance measurements. *Analog. Integr. Circ. Sig. Process*, 88, 289-302.
- [25] Pankratov, E.L., Bulaeva, E.A. (2012). Increasing of sharpness of diffusion-junction heterorectifier by using radiation processing. *Int. J. Nanosci.*, 11 (5), 1250028-1-1250028-8.
- [26] Sokolov, Yu.D. (1955). About the definition of dynamic forces in the mine lifting. *Applied mechanics*, 1 (1), 23-35.
- [27] Pankratov, E.L., Bulaeva, E.A. (2015). On approach to manufacture of a horizontal complementary field-effect heterotransistor with common gate. *J. Comp. Theor. Nanoscience*, 12 (6), 976-990.
- [28] Pankratov, E.L., Bulaeva, E.A. (2015). Optimization of manufacturing of emitter-coupled logic to decrease surface of chip. *Int. J. Mod. Phys. B*, 29 (5), 1550023-1-1550023-12.
- [29] Pankratov, E.L., Bulaeva, E.A. (2016). On optimization of technological process to decrease dimensions of transistors with several sources. *Micro and Nanosystems*, 8 (1), 52-64.
- [30] Pankratov, E.L. (2020). On increasing of elements integration rate framework a switched-capacitor step-down DC-DC converter. *Int.J.Adv.Sci.Eng*, 7 (1), 1555-1566.
- [31] Pankratov, E.L., Bulaeva, E.A. (2017). On optimization of manufacturing of transistors in hybrid cascaded multilevel inverter to increase their density. *J. Comp. Theor. Nanoscience*, 14 (7), 3548-3555.
- [32] Pankratov, E.L., Bulaeva, E.A. (2016). On optimization of growth from gas phase in a vertical reactor with account native convection to improve properties of films. *Multidiscipline Modeling in Materials and Structures*, 12 (4), 712-725.